

# Charge Exchange Inclusive Differential Cross Section Measurement

Hadron Analysis Meeting

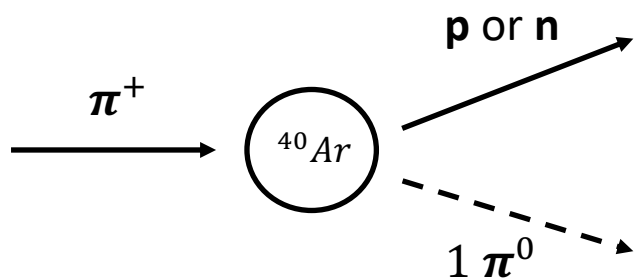
Kang Yang, University of Oxford

01 Sep. 2022

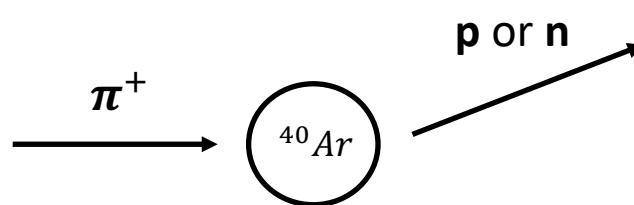
# Signal & Background Definition

- 1 GeV  $\pi^+$  beam events in ProtoDUNE-SP.

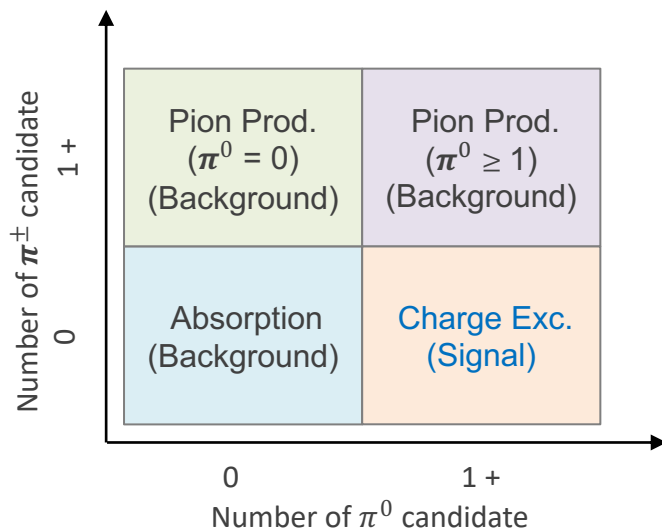
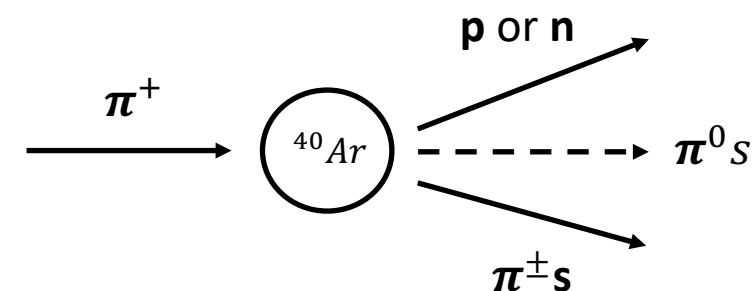
Pion Charge Exchange (signal)



Pion Absorption (background)

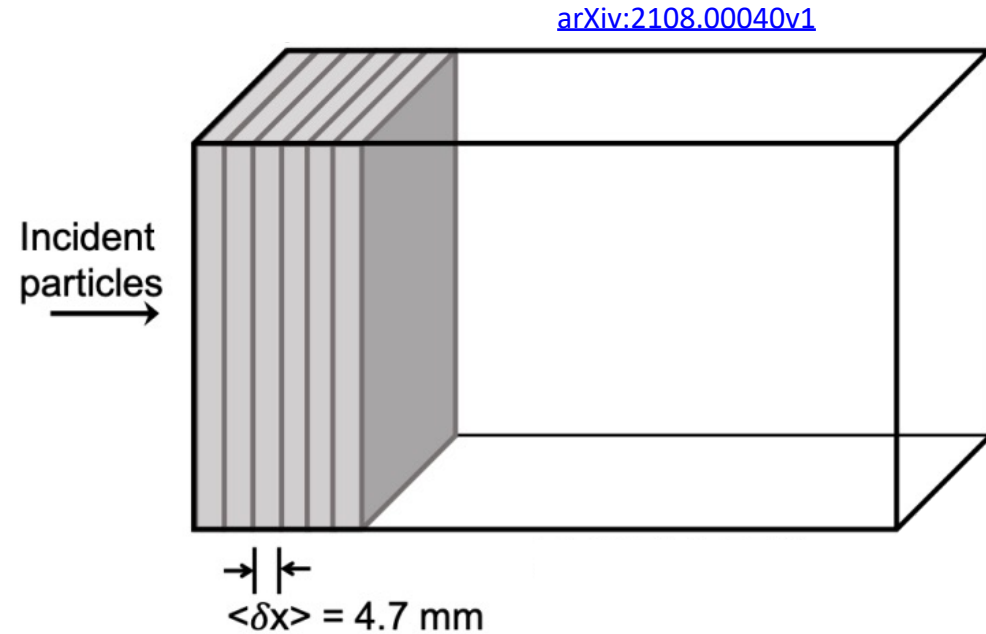
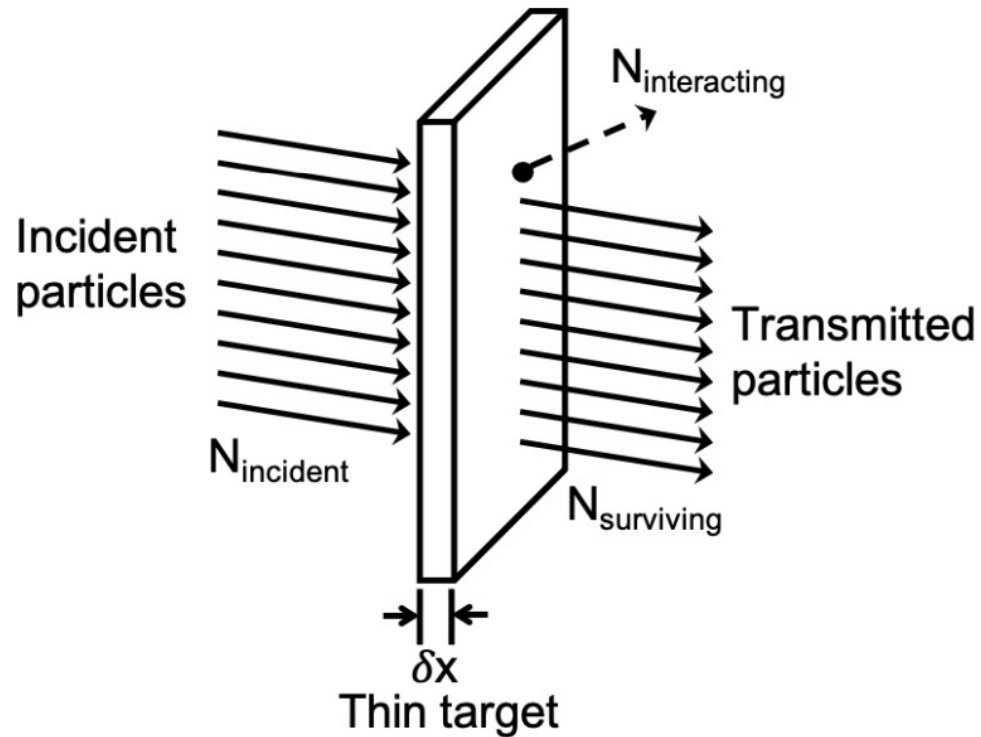


Pion Production (background)



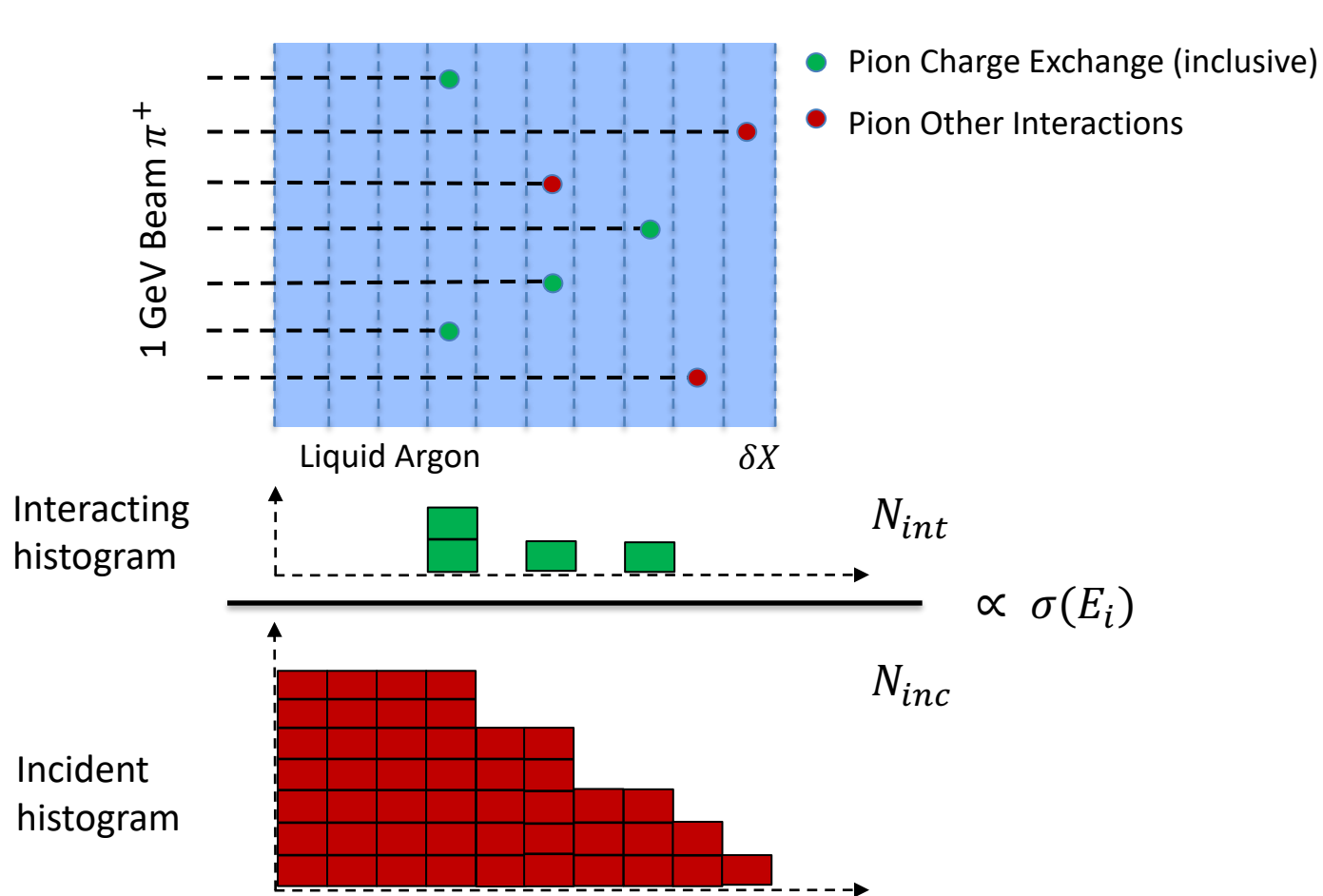
Topology	$\pi^\pm$	$\pi^0$
Pion Charge Exchange (signal)	No	Yes (only 1 $\pi^0$ )
Pion Absorption (background)	No	No
Pion Production ( $\pi^0 = 0$ ) (background)	Yes	No
Pion Production ( $\pi^0 = 1$ ) (background)	Yes	Yes (only 1 $\pi^0$ )
Pion Production ( $\pi^0 > 1$ ) (background)	Yes	Yes ( $> 1 \pi^0$ )

# Thin-Slice Method



- Interaction probability  $\frac{N_{\text{int}}}{N_{\text{inc}}} = P_{\text{Int}} = 1 - e^{-\sigma_{\text{Tot}} n \delta X}$ ,  $n = \frac{\rho N_A}{m_{\text{Ar}}}$  is the density of the target.
- The interaction length of pions in liquid argon is of the order of  $\sim 50 \text{ cm}$ .
- Treat the argon volume as a sequence of many adjacent thin targets.

# Thin-Slice Method



$$\sigma = \frac{m_{Ar}}{\rho \delta X N_A} \ln\left(\frac{N_{inc}}{N_{inc} - N_{int}}\right)$$

- ❖  $m_{Ar}$  is the mass of argon atom
- ❖  $N_A$  is the Avogadro constant
- ❖  $\rho$  is the density of liquid argon
- ❖  $\delta X$  is the thickness of the slice
- ❖  $N_{inc}$  is the number of incident beam pions in a slice
- ❖  $N_{int}$  is the number of beam pions which have interactions in a slice

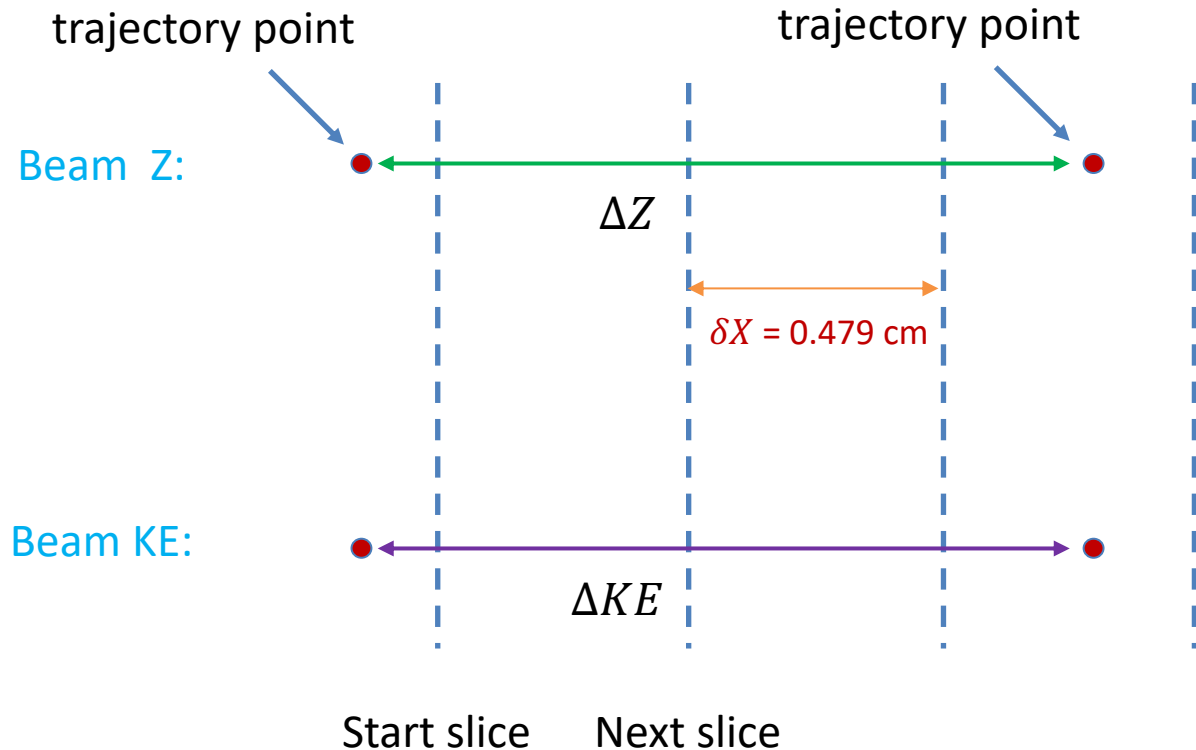
[Francesca's thesis](#)

# Method Validation (Truth Level)

# Method Validation in Truth Level

- $N_{inc}$  and  $N_{int}$  are two 1D histogram in terms of beam pion kinetic energy (KE or T).
- Two PDSP Analyzer variables are used to fill the histograms:
  - `true_beam_traj_Z` (true beam trajectory points - z coordinates)
  - `true_beam_traj_KE` (true beam trajectory points – kinetic energy)
- Spatial slicing  $\delta X = 0.479 \text{ cm}$  - wire spacing/pitch
- Each histogram has a range of 0 – 1000 MeV with a bin width of 50 MeV

# Method Validation in Truth Level



- Only include trajectory points starting in the active volume
- Only include trajectory points less than slice 464  $\approx$  222 cm (the end of APA3)
- Loop over all trajectory points
- Calculate  $\Delta Z$  and  $\Delta KE$  between adjacent points
- Use  $\frac{\delta X}{\Delta Z} = \frac{\delta E}{\Delta KE}$  to get energy slices

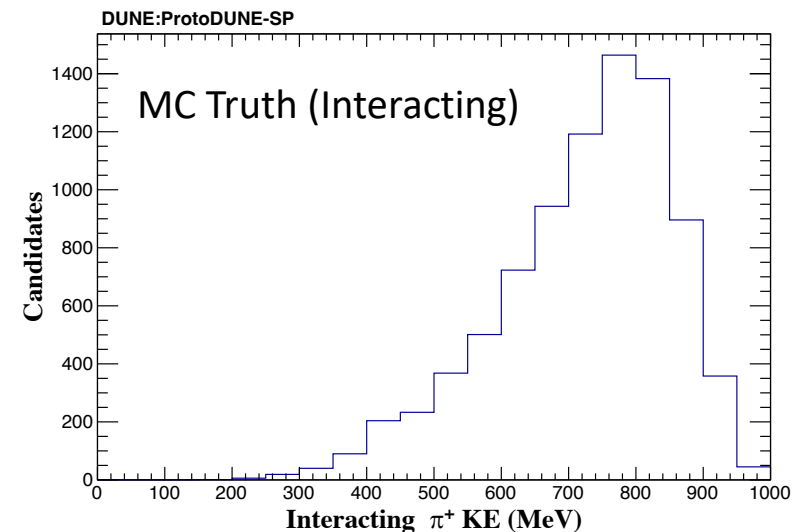
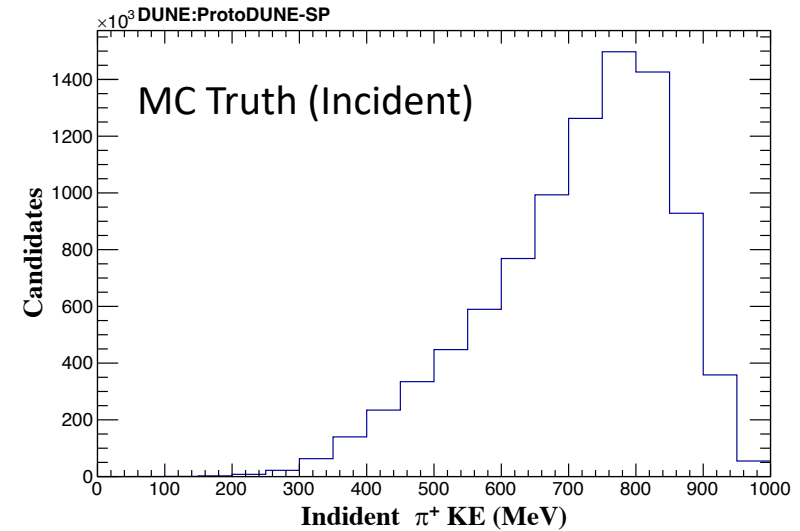
- Obtain a new beam KE vector with wire pitch (0.479 cm) slicing
- If the last trajectory point ends within the APA3, the beam interacting energy is assigned using the last element of the new beam KE vector.

# Total Truth Cross Section $\sigma_{\text{CEX}}$

- If beam PDG is 211, then loop over the new KE vector and fill  $N_{\text{inc}}$  histogram.
- If beam end process is “pi+Inelastic” and with charge exchange topology, then fill  $N_{\text{int}}$  histogram with the last element of the new KE vector .
- For each bin  $i$ , the cross section is calculated as:

$$\sigma_i = \frac{m_{\text{Ar}}}{\rho \delta X N_A} \ln \left( \frac{N_{\text{inc}}}{N_{\text{inc}} - N_{\text{int}}} \right)_i$$

- $m_{\text{Ar}} = 39.95 \text{ g/mol}$ ,  $\rho = 1.39 \text{ g/cm}^3$
- $N_A = 6.02 \cdot 10^{23} \text{ 1/mol}$ ,  $\delta X = 0.479 \text{ cm}$



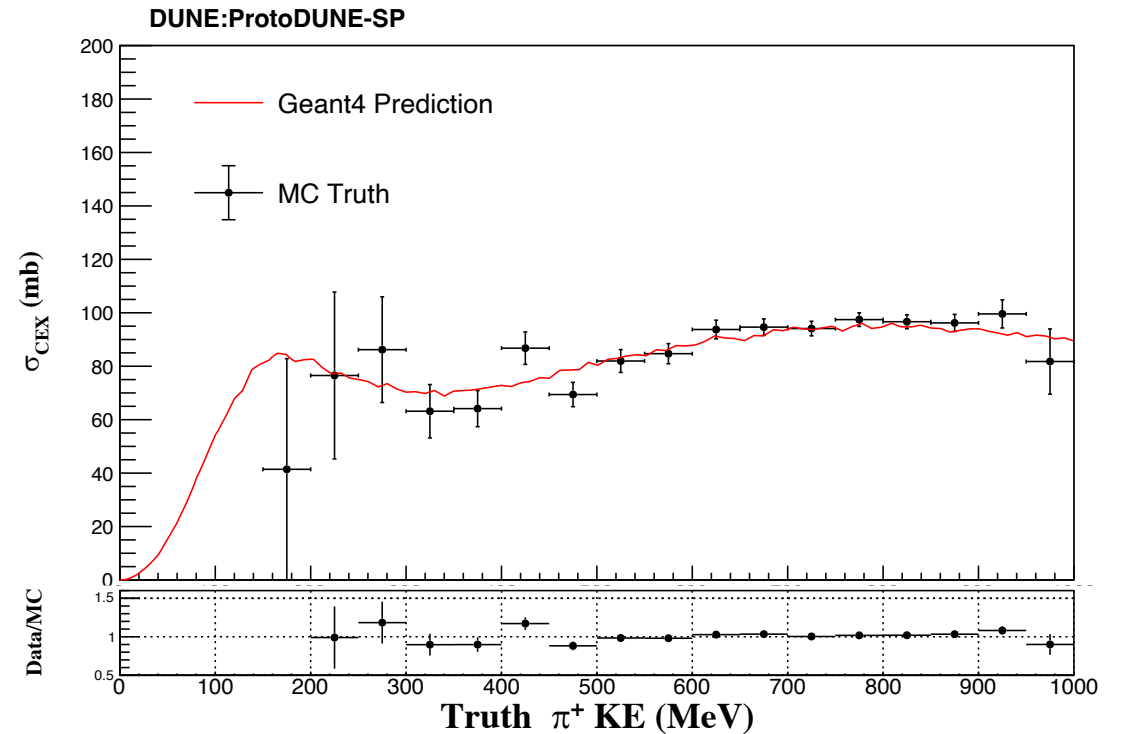


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# Differential Cross Section Formula

- Calculate the differential cross section as,

$$\left(\frac{d\sigma}{dT_{\pi^0}}\right)_{ij} = \frac{m_{Ar}}{\rho\delta X N_A} \frac{1}{(\Delta T_{\pi^0})} \frac{N_{int}^{ij}}{N_{inc}^i} \quad (\text{Eq. 1})$$

$$\sigma_i \approx \frac{m_{Ar}}{\rho\delta X N_A} \frac{N_{int}^i}{N_{inc}^i}$$

- Thin slice total CEX cross section is,

$$\sigma_i = \frac{m_{Ar}}{\rho\delta X N_A} \frac{N_{int}^i}{N_{inc}^i} \quad (\text{Eq. 2})$$

$\Delta T_{\pi^0}$  is the bin width of  $\pi^0$  KE

Index i : beam  $T_{\pi^+}$  bin,

Index j : daughter  $T_{\pi^0}$  bin

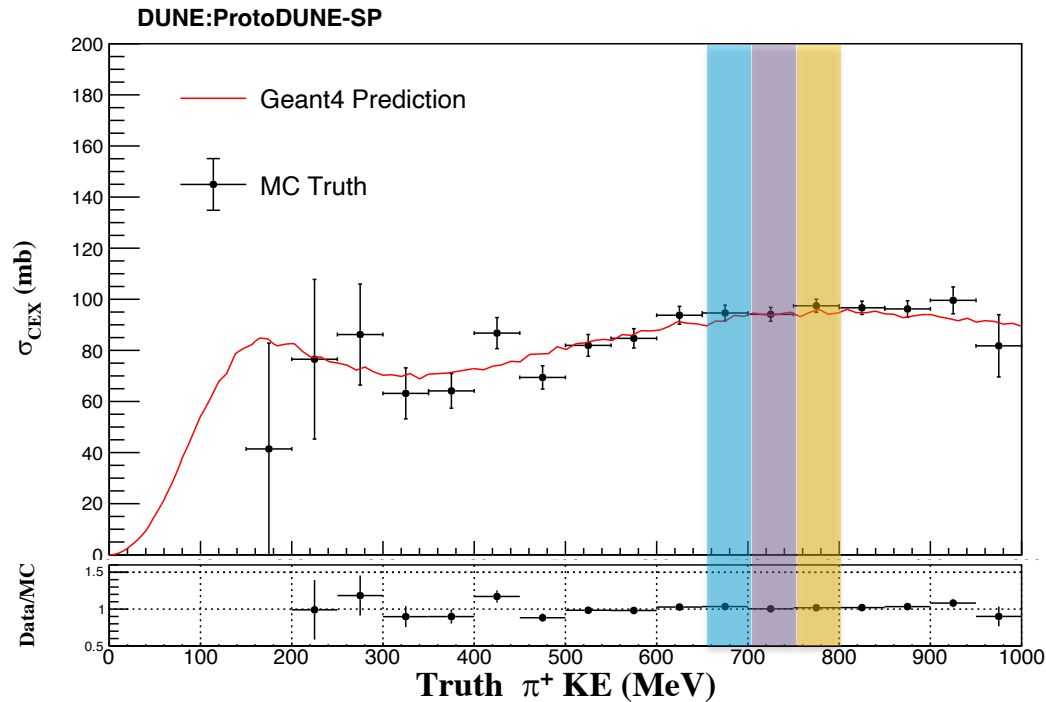
- Then the differential cross section formula is (Sub. Eq. 2 into Eq. 1),

$$\left(\frac{d\sigma}{dT_{\pi^0}}\right)_{ij} = \frac{1}{(\Delta T_{\pi^0})} \frac{N_{int}^{ij}}{N_{int}^i} \sigma_i$$

Thank you Jonathon Sensenig for useful discussions!

# GEANT4 and Truth $d\sigma$ Calculation

- The **Geant4Rewight** package is used to extract the differential cross section,  $\frac{d\sigma}{dT}$
- Measure differential XS at each bin  $i$  (for a given pion KE).



- Pion KE = 675 MeV → Evaluate  $\sigma_{KE=675 \text{ MeV}}$
- Pion KE = 775 MeV → Evaluate  $\sigma_{KE=775 \text{ MeV}}$
- Pion KE = 875 MeV → Evaluate  $\sigma_{KE=875 \text{ MeV}}$

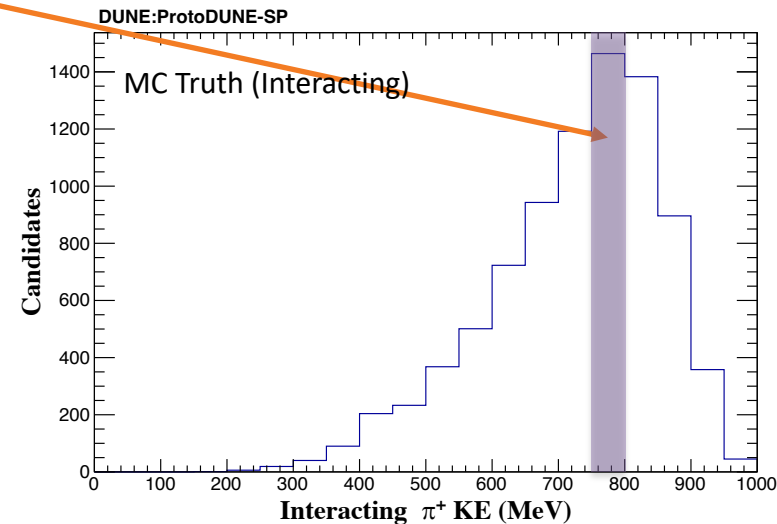
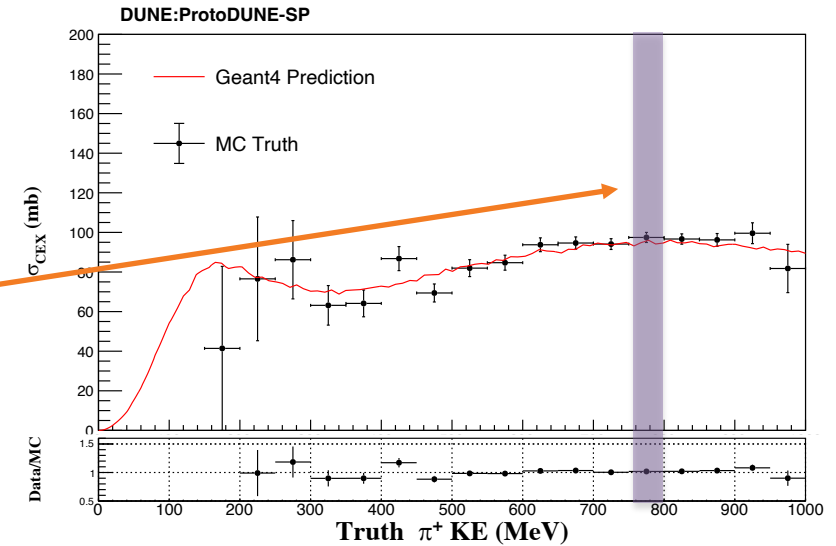
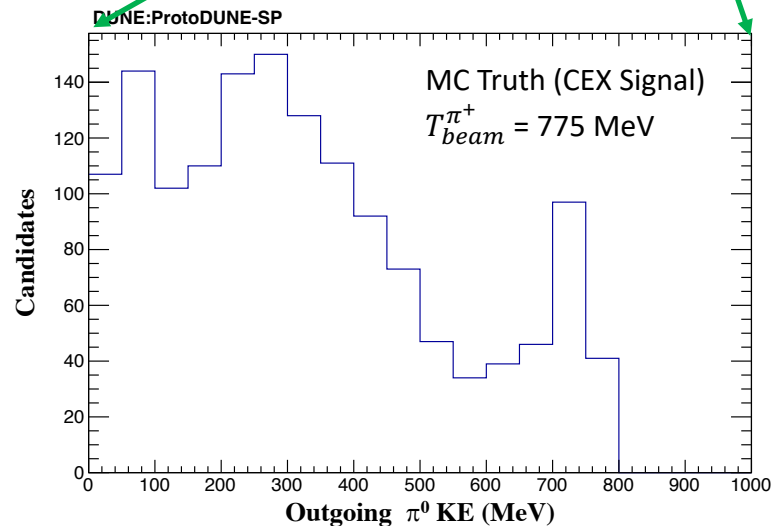
- Differential XS for bin  $j$  (daughter  $T_{\pi^0}$  bin) is,

$$\left(\frac{d\sigma}{dT_{\pi^0}}\right)_j = \frac{1}{(\Delta T_{\pi^0})} \frac{N_{int}^j}{N_{int}} \sigma_{KE=775 \text{ MeV}}$$

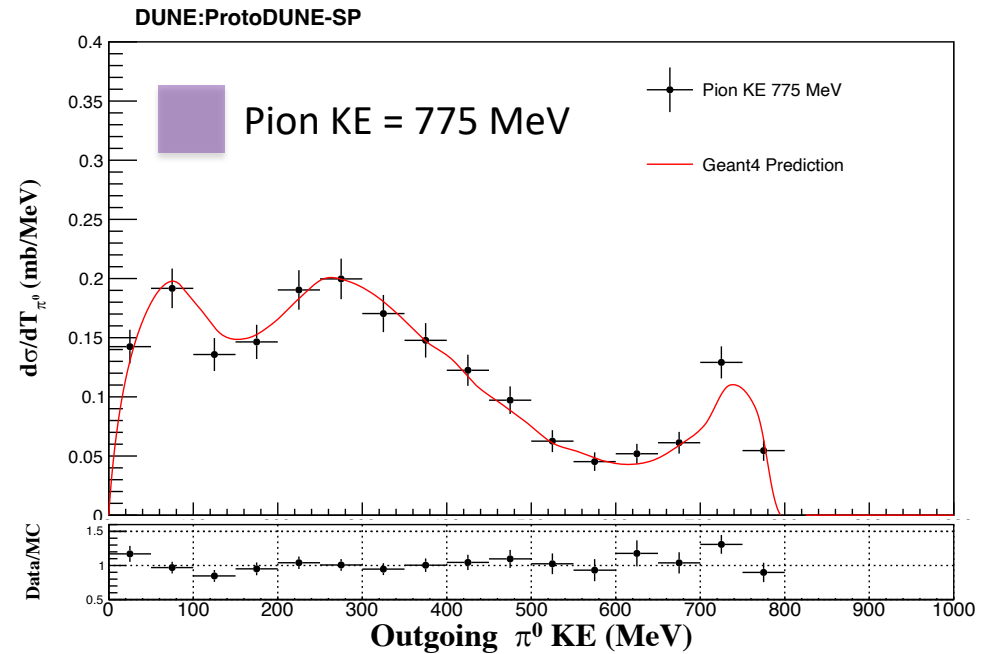
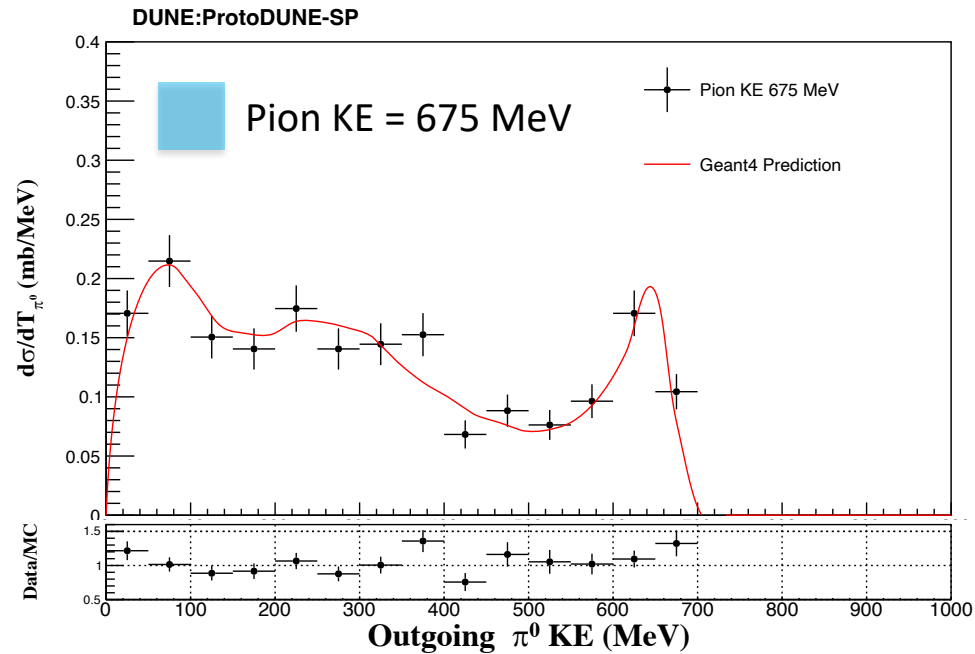
# dσ Validation in Truth Level

- Differential XS for bin j (daughter  $T_{\pi^0}$  bin) with  $T_{beam}^{\pi^+} = 775$  MeV is,

$$\left(\frac{d\sigma}{dT_{\pi^0}}\right)_j = \frac{1}{(\Delta T_{\pi^0})} \frac{N_{int}^j}{N_{int}} \sigma_{KE=775 \text{ MeV}}$$



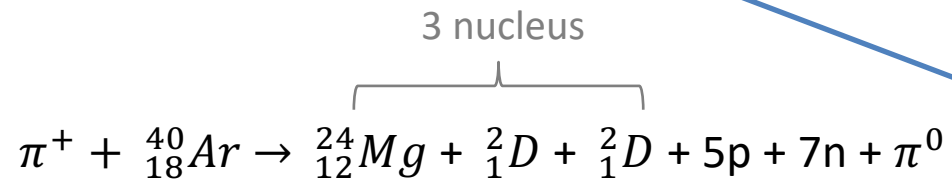
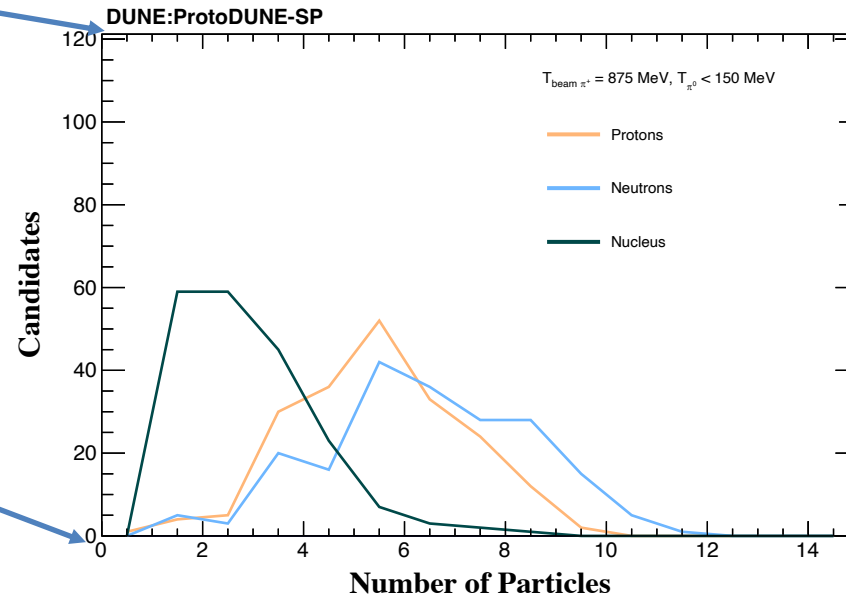
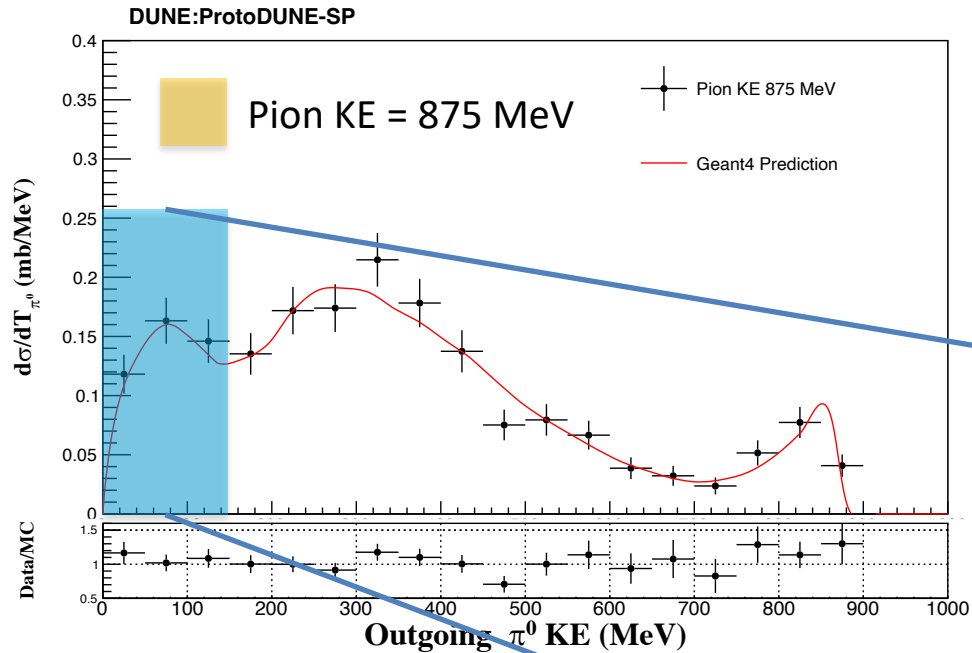
# $d\sigma$ Validation in Truth Level



- The differential cross section formula works well in truth level.
- There are three peaks in the differential cross section distribution.

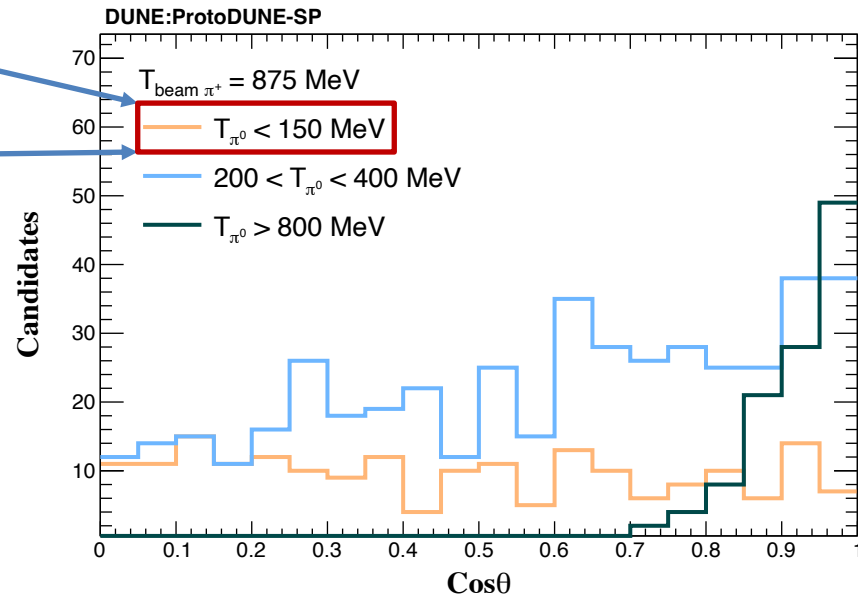
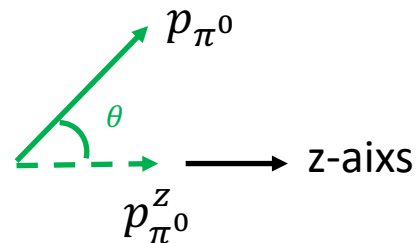
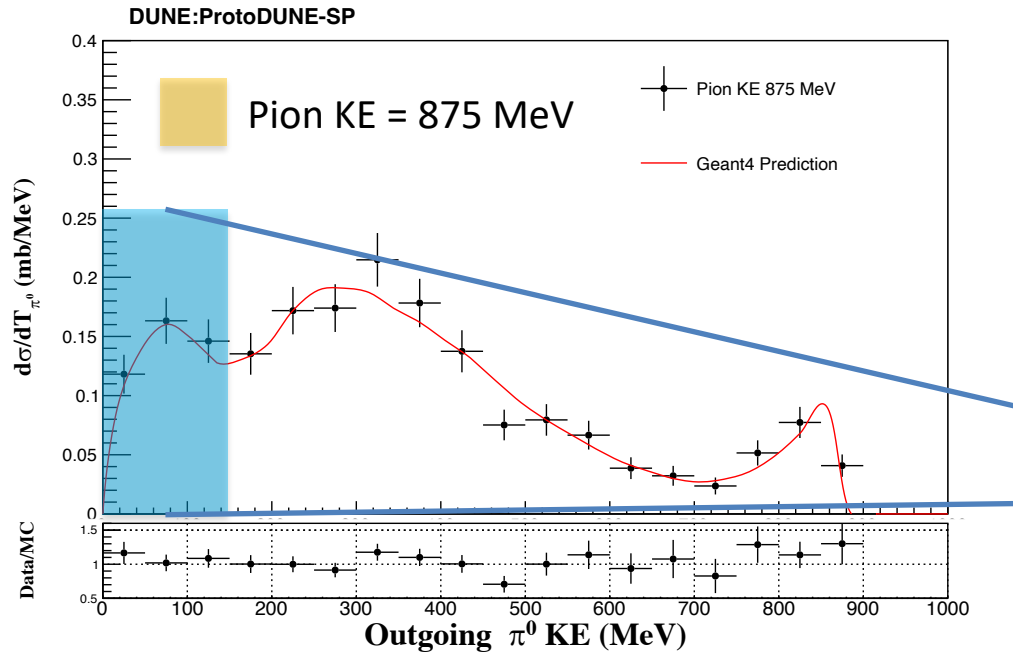
# Low $T_{\pi^0}$ Region

- Nucleus is defined as PDG > 2212, such as a deuteron,  $He^3$ ,  $He^4$  and nucleus.
- Many daughter nucleons and 1  $\pi^0$ .
- The direction of  $\pi^0$  is arbitrary.



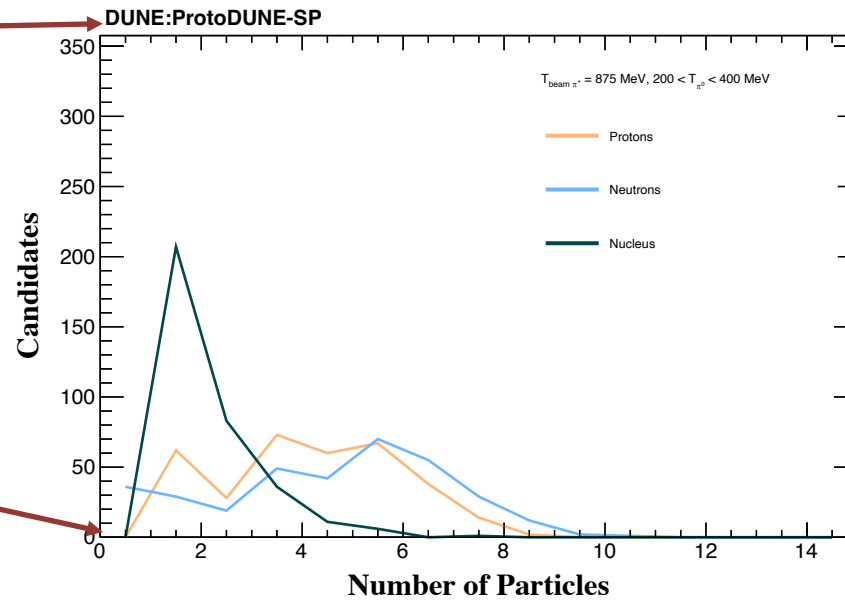
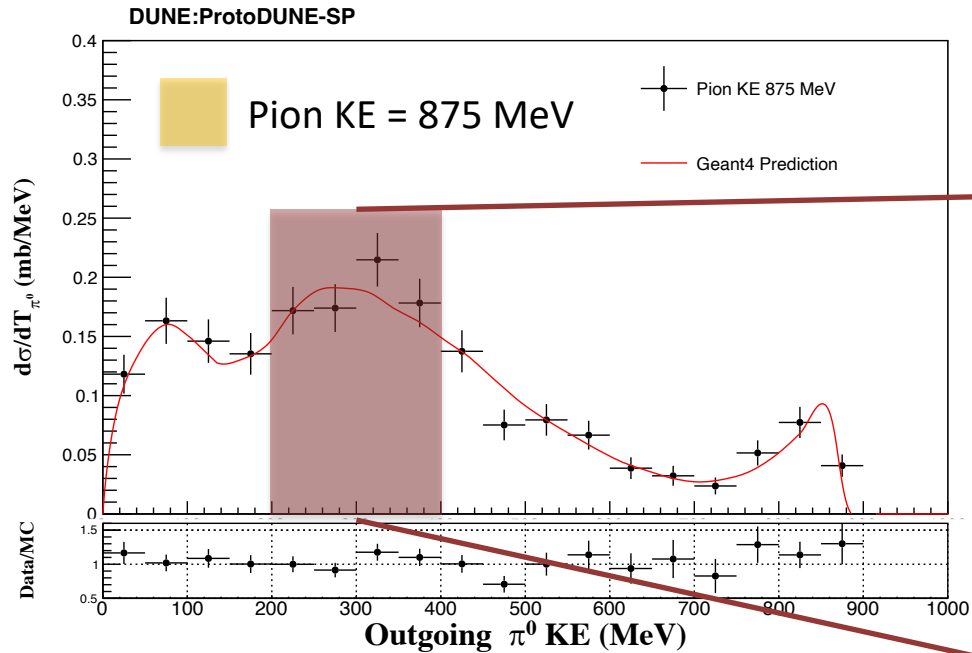
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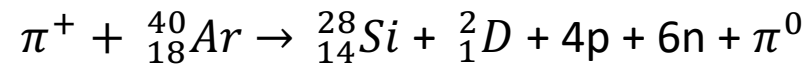


# Middle $T_{\pi^0}$ Region

- Less nucleons are produced.



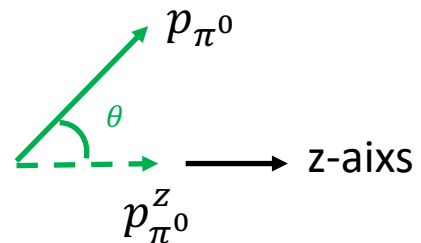
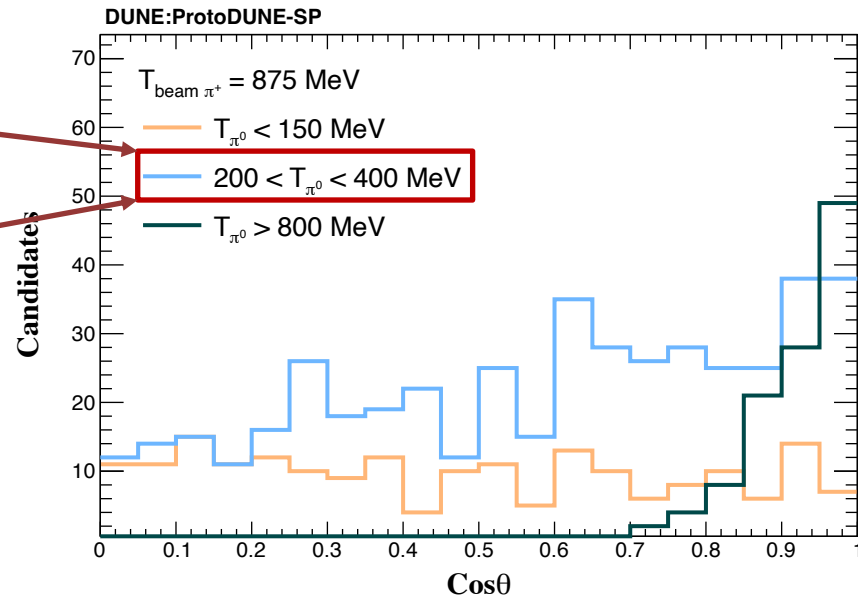
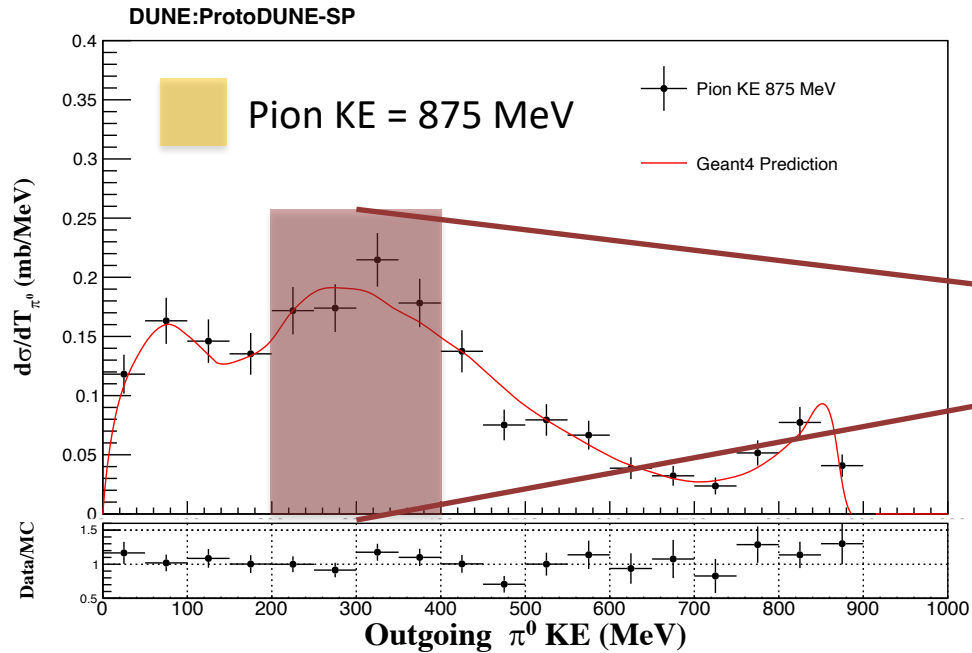
2 nucleus



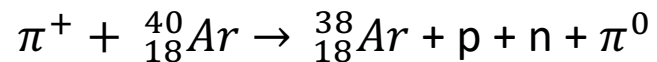
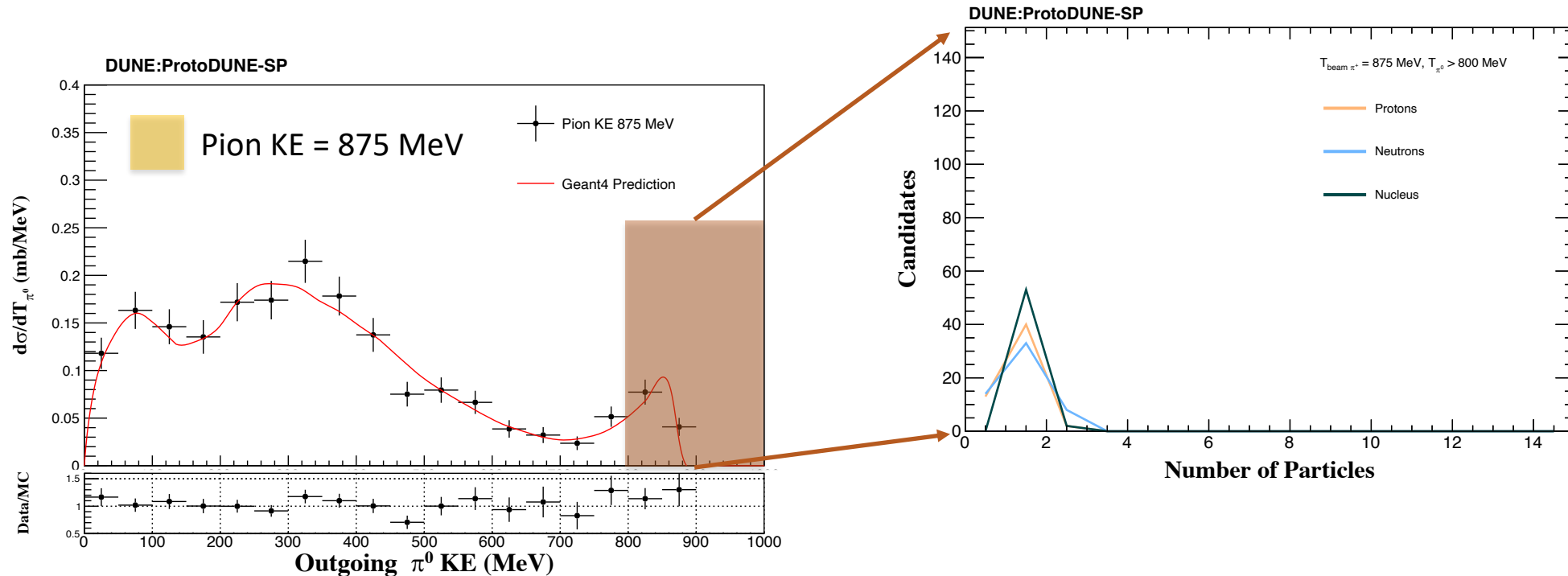


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- Less nucleons are produced.

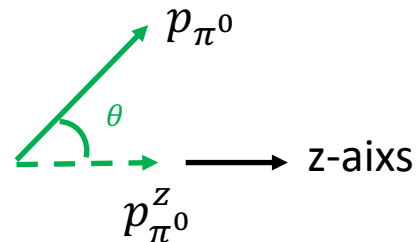
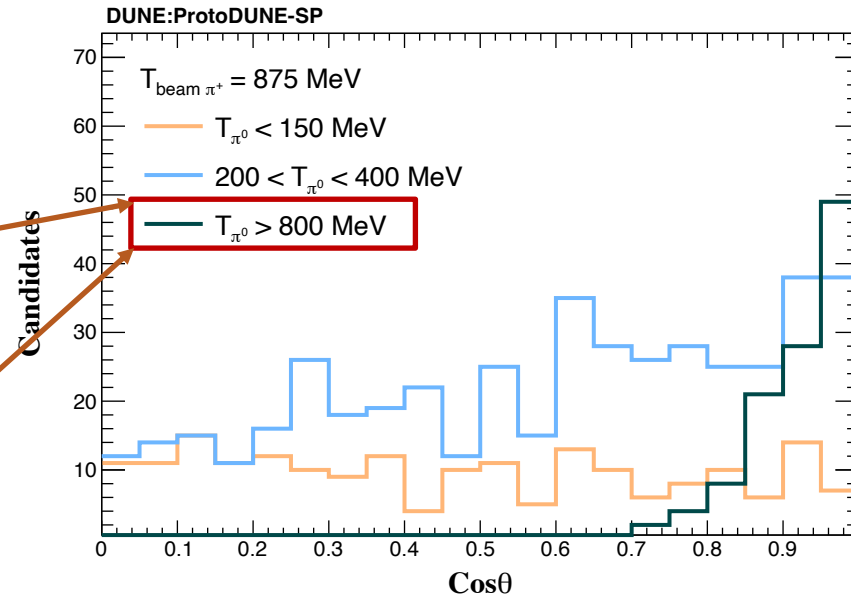
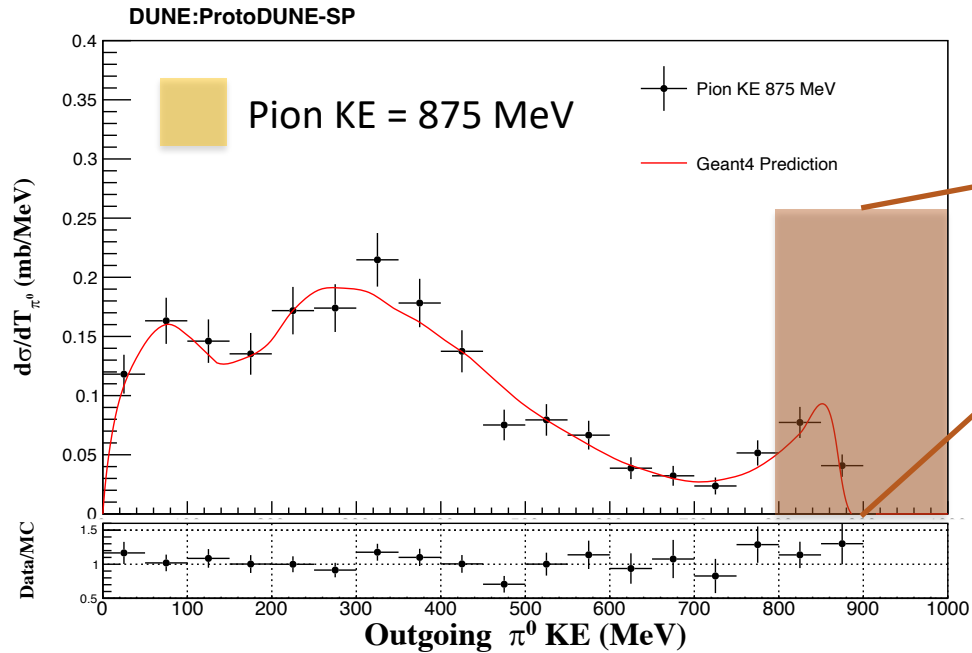


# High $T_{\pi^0}$ Region



- Only one Argon isotope (such as  $Ar^{39}, Ar^{38}$ ) is produced.
- One or two nucleons and 1  $\pi^0$ .
- The direction of  $\pi^0$  is forward.

# High $T_{\pi^0}$ Region



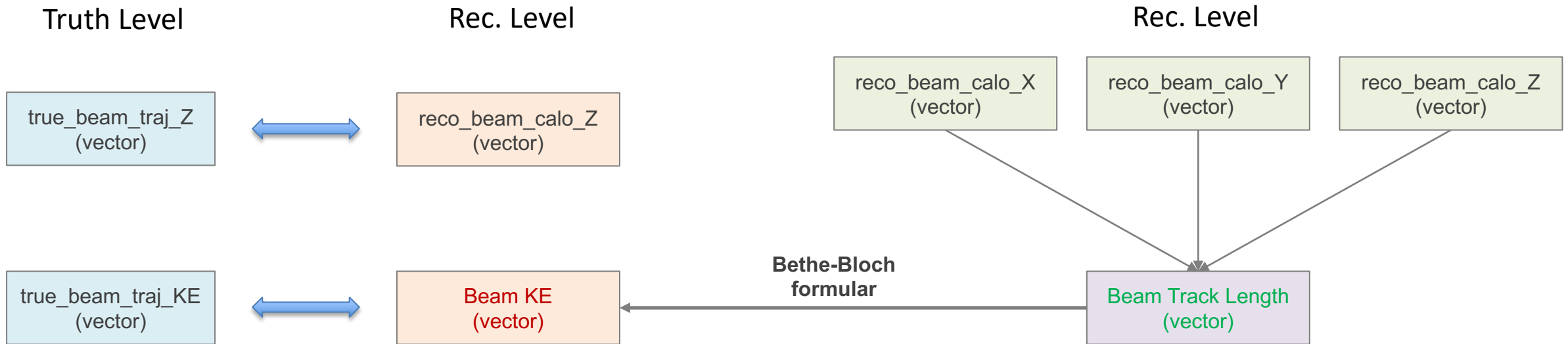
- Only one Argon isotope (such as  $Ar^{39}, Ar^{38}$ ) is produced.
- One or two nucleons and 1  $\pi^0$ .
- The direction of  $\pi^0$  is forward.

# Fake Data Test (Rec. Level)

# Fake Data

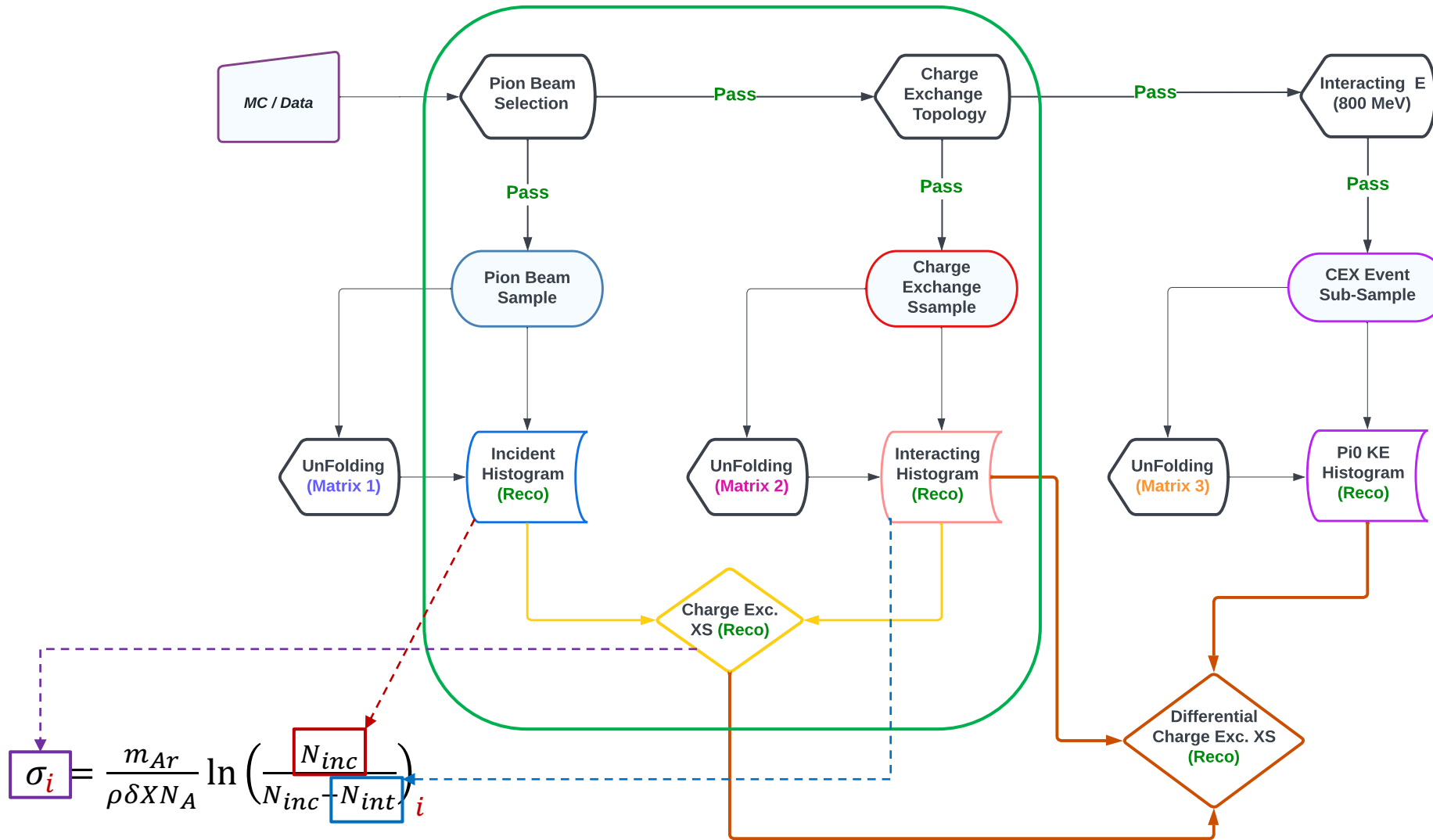
- Full 1GeV Pion MC sample is divided into 2 sub-samples.
  1. Fake Data
  2. MC
- MC sample is used to train the mapping response matrix for unfolding.
- Fake Data is used to validate the cross section extraction procedures.
- The unfolding is done using RooUnfold package (iterative Bayesian method, 4 iteration)

# Rec. Beam Kinetic Energy

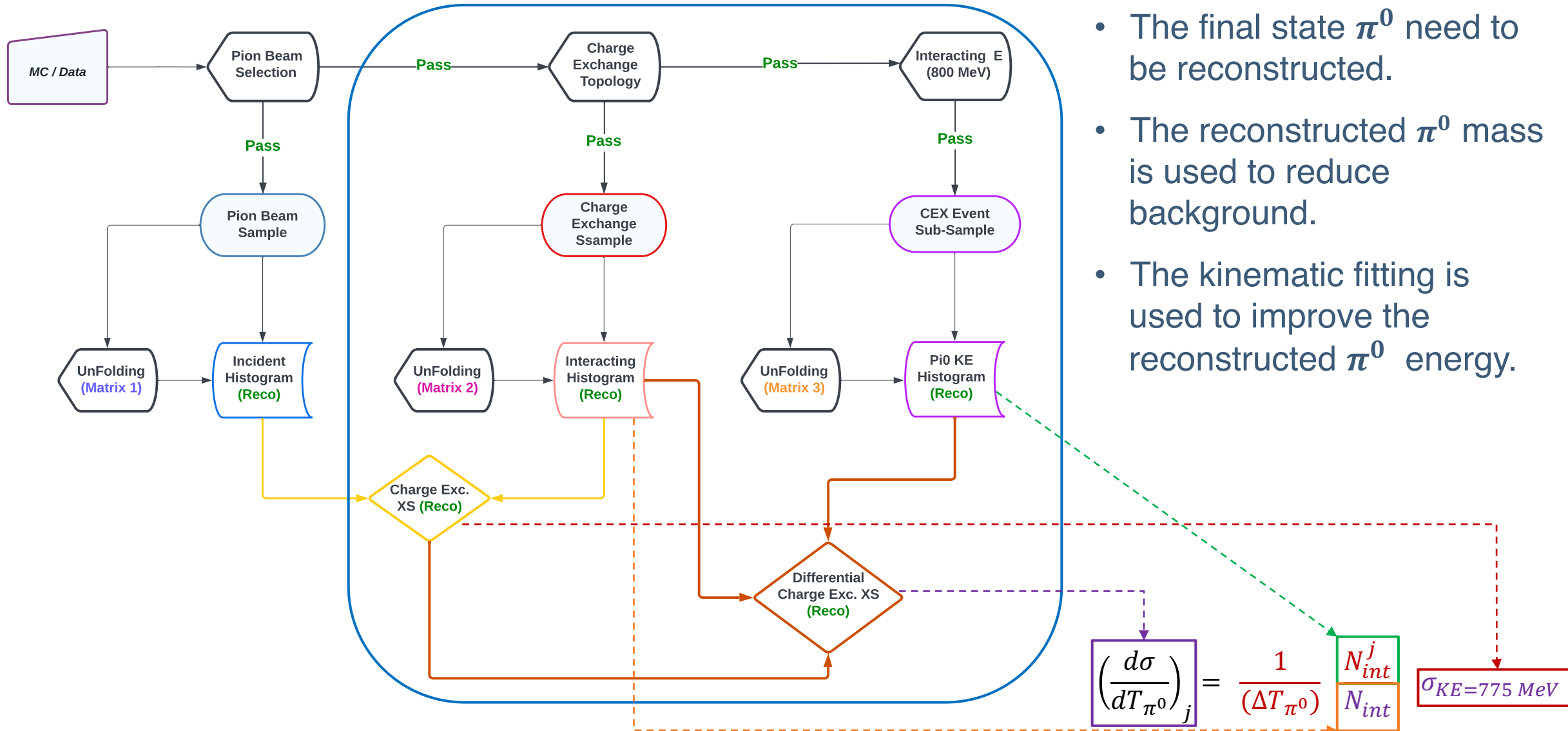


- There is no PDSP Analyzer variable to describe the kinetic energy of the beam pion.
- The beam track length is calculated using XYZ positions at each space point.
- Convert the track length to kinetic energy using pion assumption in the Bethe-Bloch formular.

# Analysis Flowchart



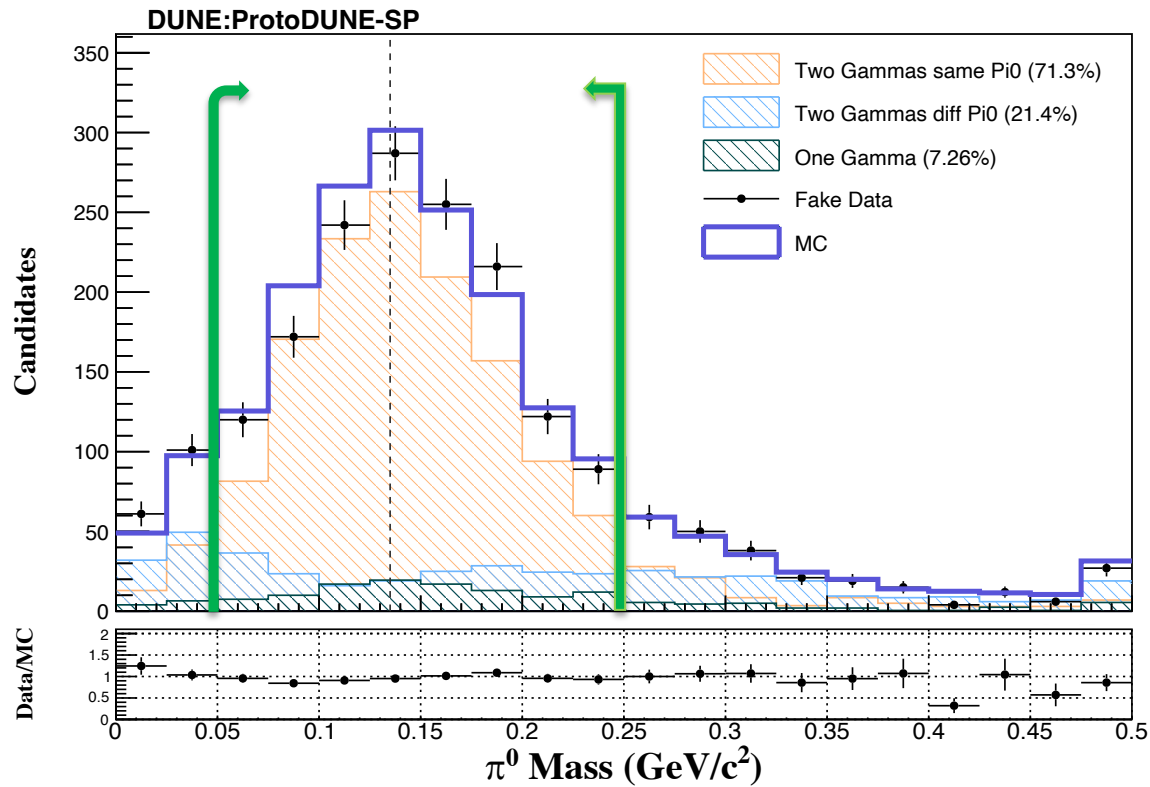
# Analysis Flowchart



- The final state  $\pi^0$  need to be reconstructed.
- The reconstructed  $\pi^0$  mass is used to reduce background.
- The kinematic fitting is used to improve the reconstructed  $\pi^0$  energy.

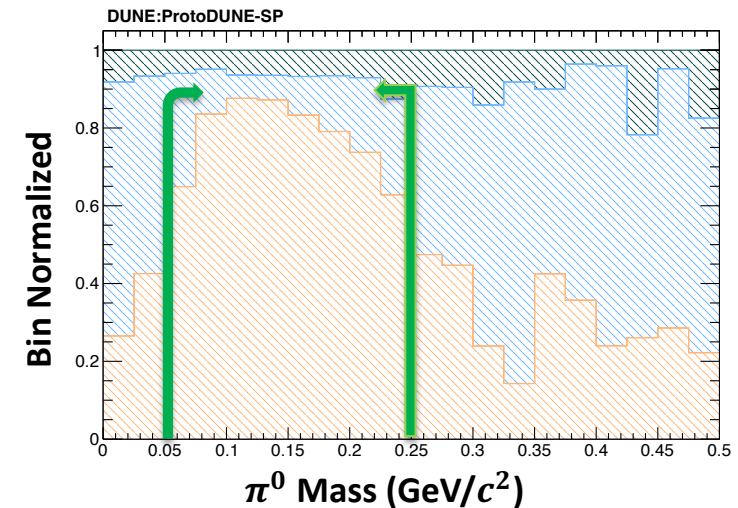


# Reconstructed $\pi^0$ Mass



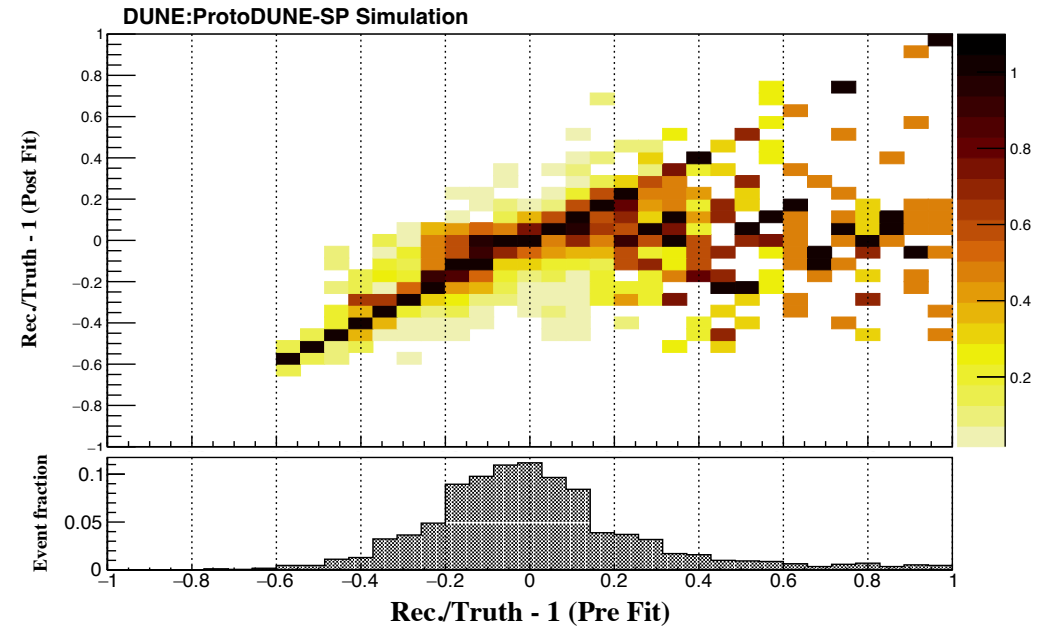
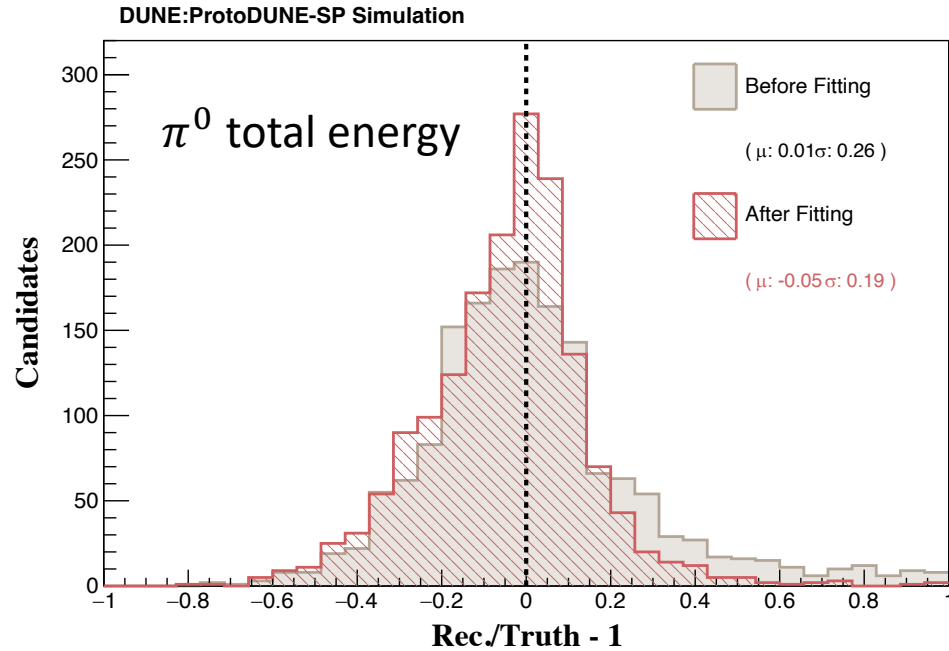
- $\pi^0$  Mass distribution **after** shower energy and angle correction.

- Truth  $\pi^0$  Mass is indicated by the dash line.
- The invariant mass peak from the **signal (two gammas from same  $\pi^0$ )** looks good!
- There is a continuous background from two gammas coming from different  $\pi^0$ .
- **One Gamma background** means there is at least one non-photon candidate.



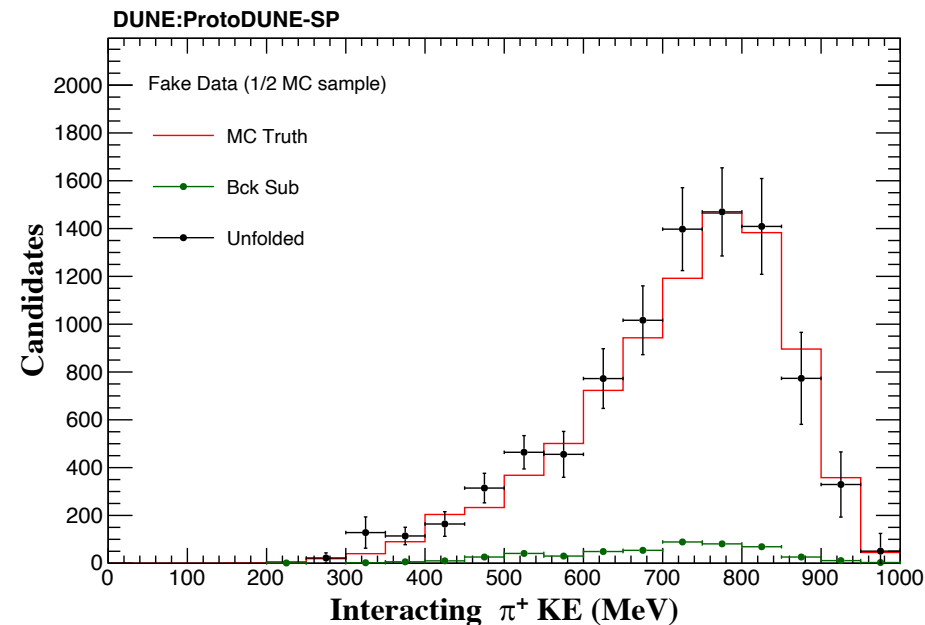
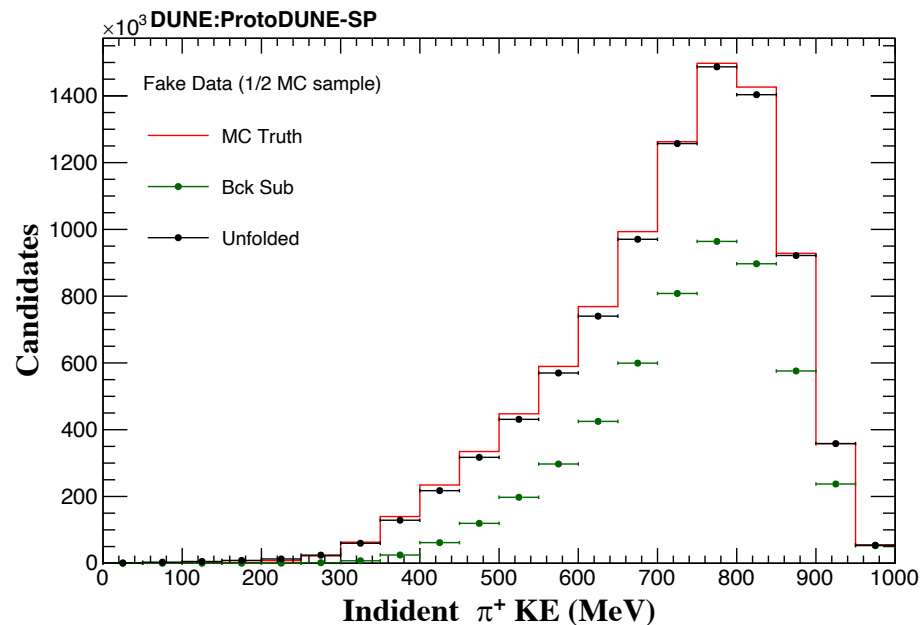
# $\pi^0$ Kinematic Fitting

$$E_\pi = E_1 + \frac{m_{\pi^0}^2}{2E_1(1 - \cos\theta)}$$



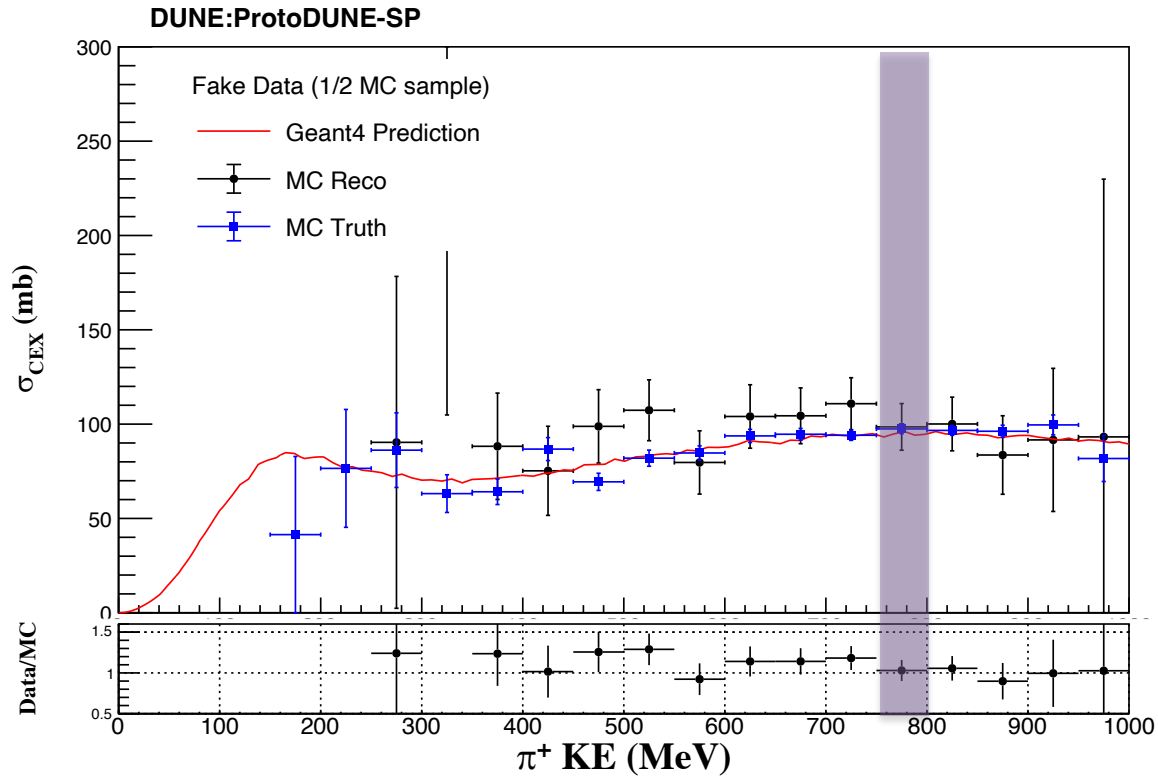
- The reconstructed  $\pi^0$  energy bias looks pretty good after fitting.
- The spread of the distribution is reduced from 0.26 to 0.19 (see in legend).
- KF has a larger impact on events where the  $\pi^0$  energy is overestimated.

# Background Subtraction & Unfolding



- Mapping response matrix is trained using half of the total MC.
- The other half of the MC is used to test the unfolding procedures.
- The red histogram is computed using the truth information of the fake data sample.

# Total Cross Section $\sigma_{\text{CEX}}$ Measurement



- MC Reco is the fake data sample after background subtraction and unfolding.
- MC Truth is derived using the truth information of the fake data sample.
- Above **400 MeV**, both Rec. and Truth agree with the Geant4 prediction well.

# Differential Cross Section Formula

- Calculate the differential cross section as,

$$\left(\frac{d\sigma}{dT_{\pi^0}}\right)_{ij} = \frac{m_{Ar}}{\rho\delta X N_A} \frac{1}{(\Delta T_{\pi^0})} \frac{N_{int}^{ij}}{N_{inc}^i} \quad (\text{Eq. 1})$$

$$\sigma_i \approx \frac{m_{Ar}}{\rho\delta X N_A} \frac{N_{int}^i}{N_{inc}^i}$$

- Thin slice total CEX cross section is,

$$\sigma_i = \frac{m_{Ar}}{\rho\delta X N_A} \frac{N_{int}^i}{N_{inc}^i} \quad (\text{Eq. 2})$$

$\Delta T_{\pi^0}$  is the bin width of  $\pi^0$  KE

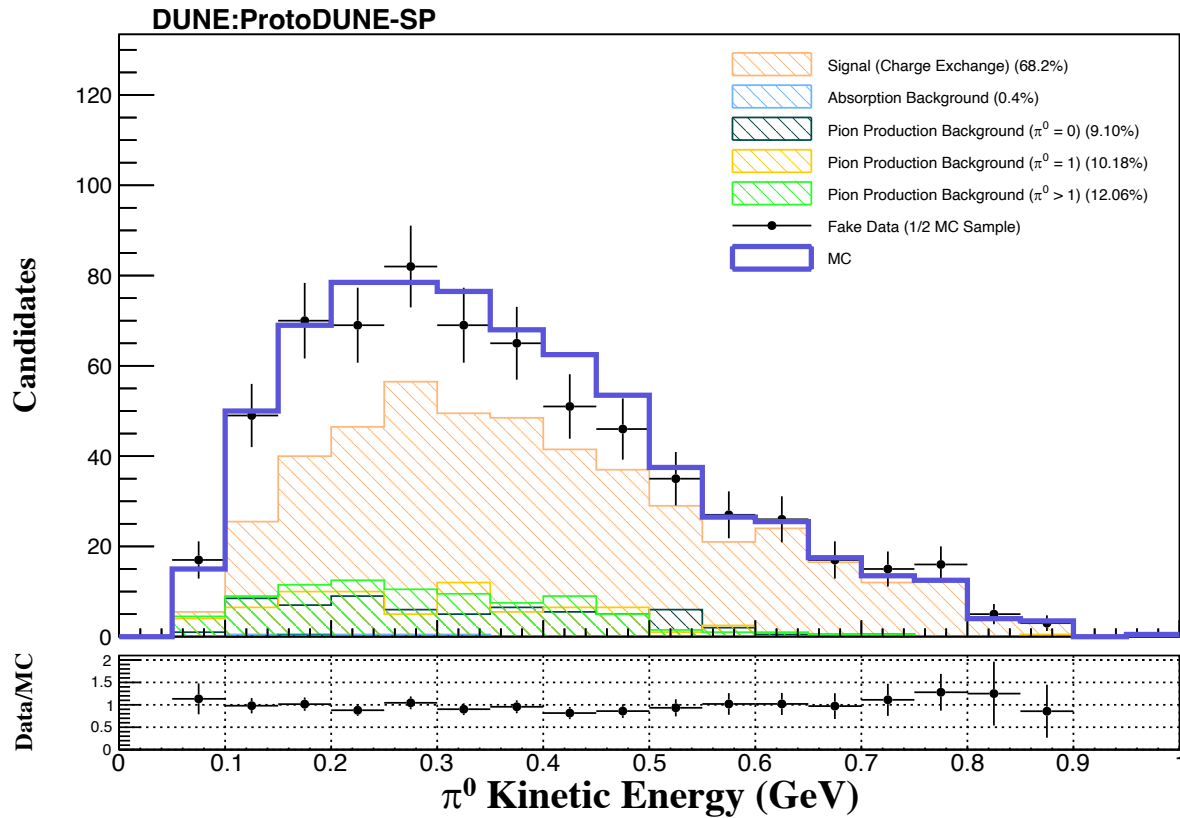
Index i : beam  $T_{\pi^+}$  bin,

Index j : daughter  $T_{\pi^0}$  bin

- Then the differential cross section formula is (Sub. Eq. 2 into Eq. 1),

$$\left(\frac{d\sigma}{dT_{\pi^0}}\right)_{ij} = \frac{1}{(\Delta T_{\pi^0})} \frac{N_{int}^{ij}}{N_{inc}^i} \sigma_i$$

# $\pi^0$ Kinetic Energy Reconstruction



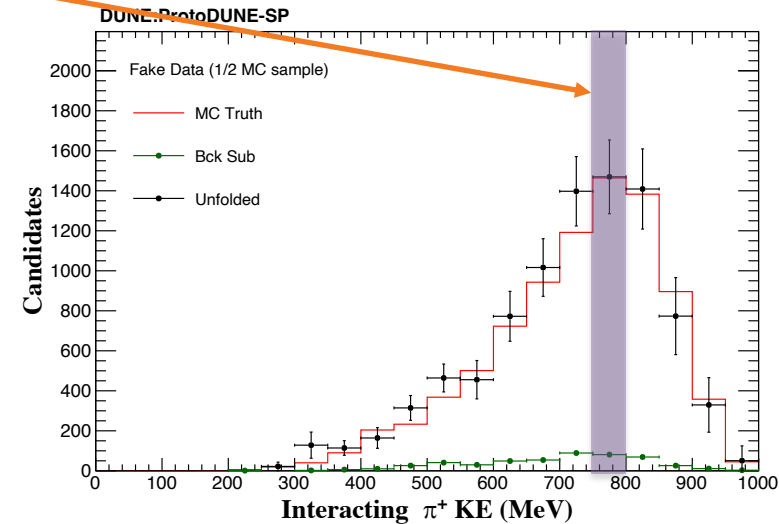
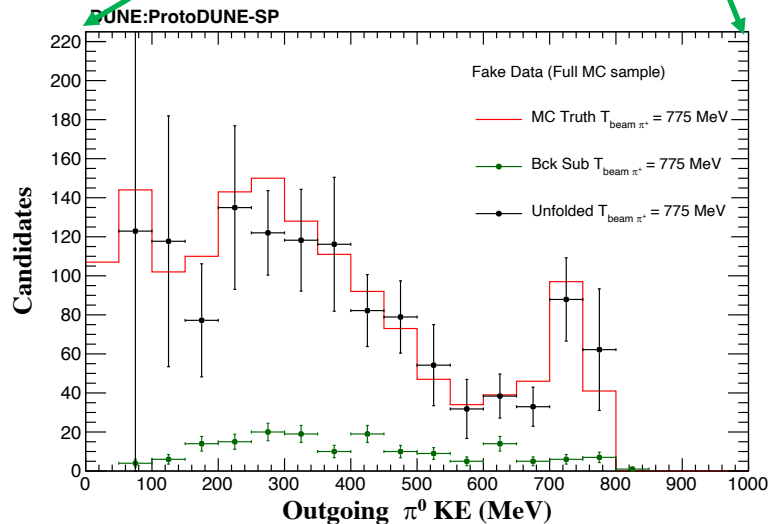
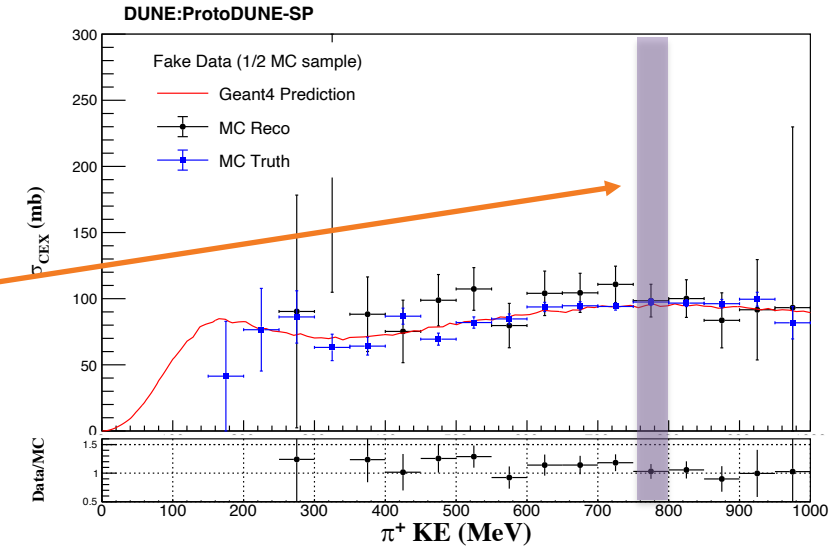
! All Rec. Pion Beam Sample !

- Reconstructed  $\pi^0$  kinetic energy distribution from after event topology cut.
- Event topology definitions can be found in page 2.
- Signal (charge exchange) is around 68%.
- The largest background is pion production with  $\pi^0 > 1$  (12%)
- No phase space cut on daughter  $\pi^{+/-}$  (cannot detect pion with mom.  $< 150$  MeV)

# Towards $d\sigma$ Measurement

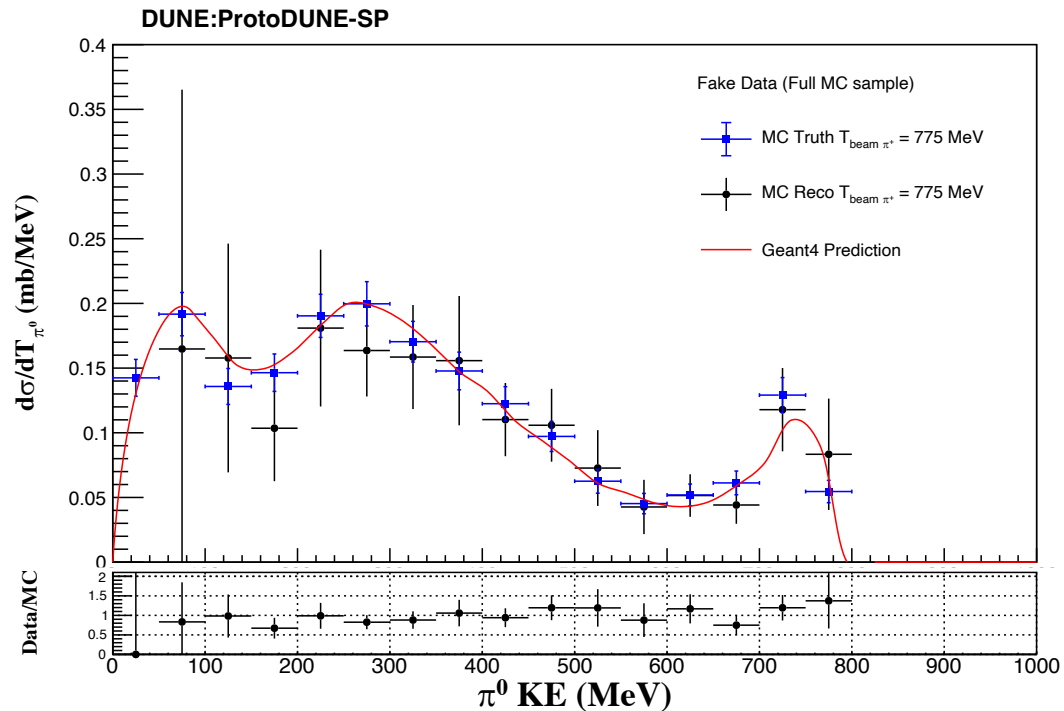
- Differential XS for bin  $j$  (daughter  $T_{\pi^0}$  bin) is,

$$\left(\frac{d\sigma}{dT_{\pi^0}}\right)_j = \frac{1}{(\Delta T_{\pi^0})} \frac{N_{int}^j}{N_{int}} \sigma_{KE=775 \text{ MeV}}$$



# Diff. Cross Section $d\sigma/dT_{\pi^0}$

- Beam pion interacts between 750 - 800 MeV and produces one  $\pi^0$  (Charge Ex.).

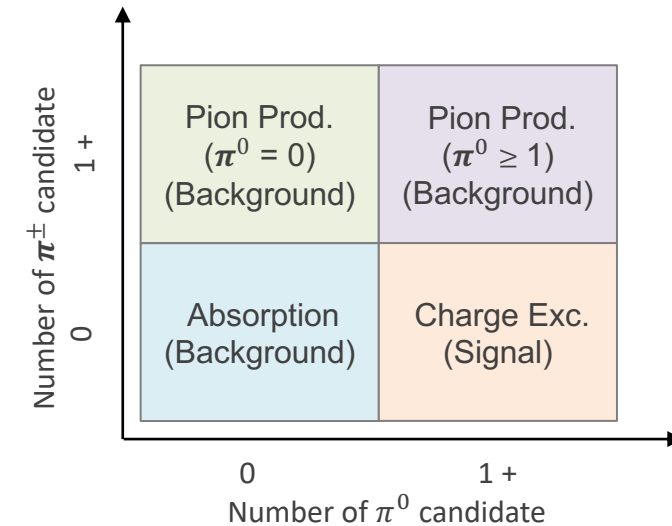


- The full MC sample was used in the rec. calculation to increase the statistics.
- The statistical error is quite large for the low  $T_{\pi^0}$  region.
- Both Rec. and Truth agree well with the Geant4 prediction.



# Towards Real Data $d\sigma$ Measurement

- The differential cross section measurements were validated using fake data.
- Background constraints need to be done using sideband channels (data-driven method):
  - ❖ Fit three scaling factors in each background channel.
  - ❖ Find scaling factors as a function of  $T_{\pi^0}$
  - ❖ Use scaling factors to tune the background component in signal channel.



- One-dimensional unfolding may not be enough, need more studies and tests.

# Summary

- The formula for computing the differential cross section is discussed.
- Truth-level validation is performed and shows good agreement with Geant4 input.
- Fake data sample (1/2 of MC sample) is used to perform the charge exchange cross section.
- After unfolding, both MC Reco and Truth of the fake data sample agrees well with the Geant4 input.
- Need to study more on background constraints and unfolding when move on to the real data sample.

# $\pi^0$ Decay Kinematics

- Invariant mass of two photons:

$$\diamond m_{\gamma\gamma}^2 = 2E_1E_2(1 - \cos(\theta))$$

- Minimizing (Full CVM):

$$\diamond \chi^2 = \lambda * \{2 * E_1E_2[1 - \cos(\theta)] - m_{\gamma\gamma}^2\} + (\alpha - \alpha_0)V_{\alpha_0}^{-1}(\alpha - \alpha_0)$$

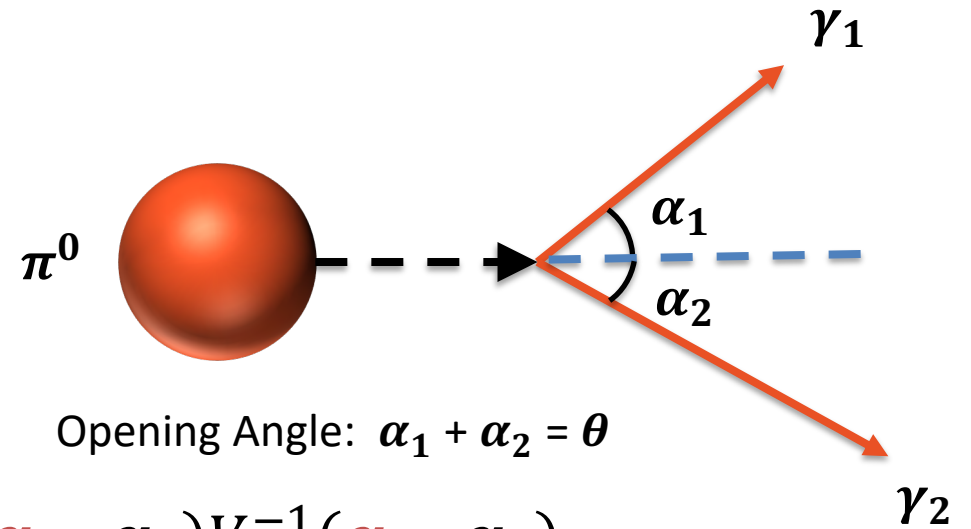
$$\diamond \text{where } \alpha = (E_1 \quad E_2 \quad \theta)$$

$$\diamond V_{\alpha_0}^{-1} \text{ is the inverse of the full CVM matrix}$$

- Minimizing (Only diagonal CVM):

$$\diamond \chi^2 = \lambda * \{2 * E_1E_2[1 - \cos(\theta)] - m_{\gamma\gamma}^2\} + \sum_i (\alpha_i - \alpha_{0_i})^2 / \sigma_i^2$$

$$\diamond \text{we set the off diagonal elements to be 0}$$



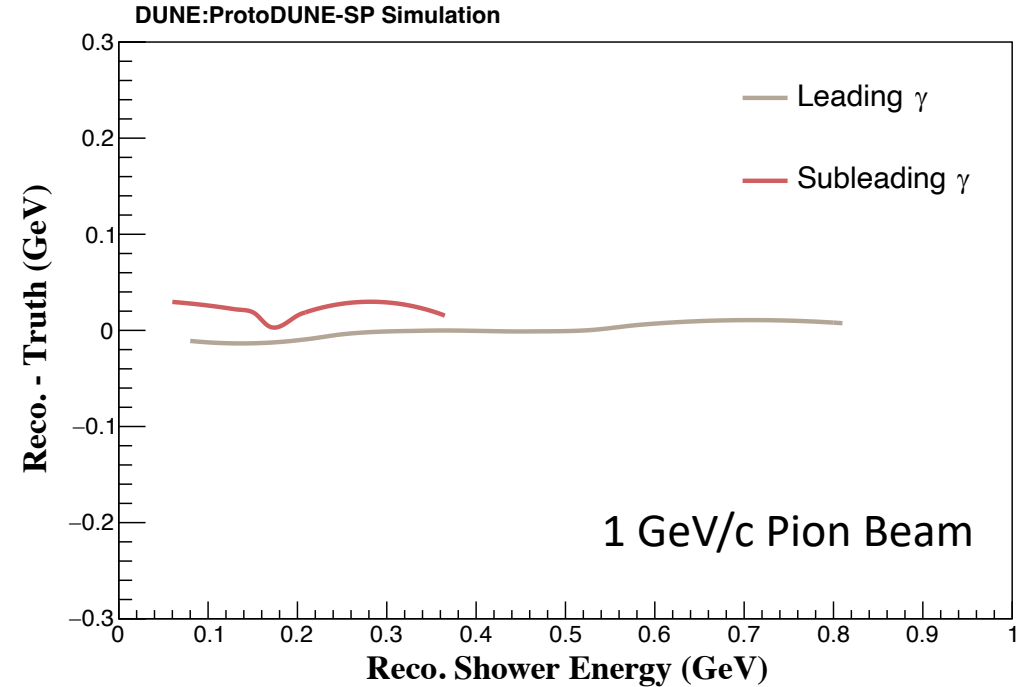
# CVM Calculation

Variables	Matched Terms
Truth $E_1$	$E[X_i]$
Truth $E_2$	$E[X_j]$
Measured $e_1$	$X_i$
Measured $e_2$	$X_j$

CVM element:  $V_{X_i X_j} = E[(X_i - E[X_i])(X_j - E[X_j])^T]$

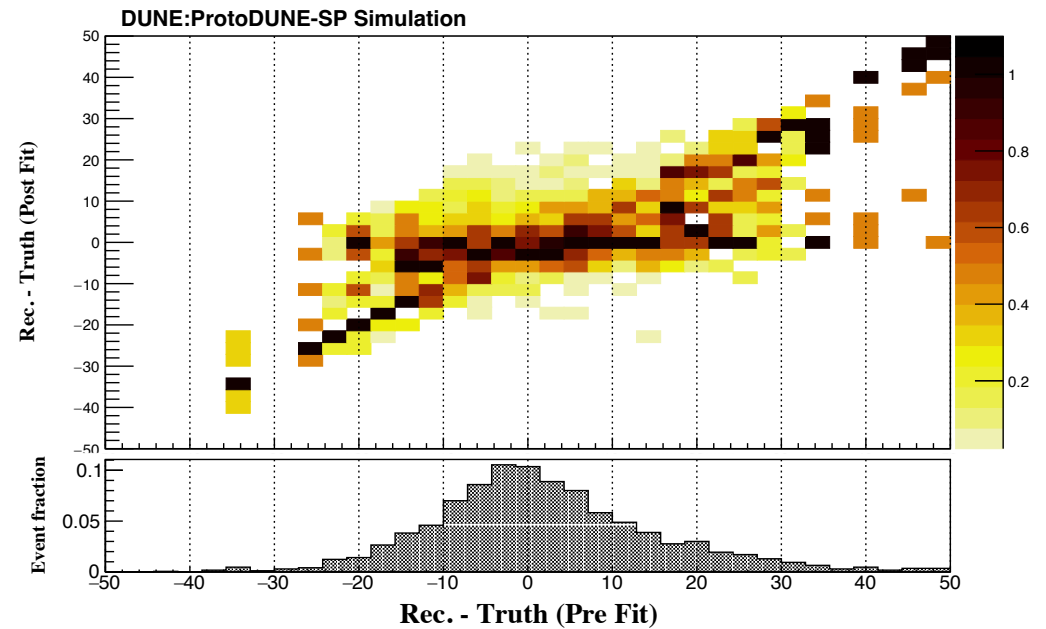
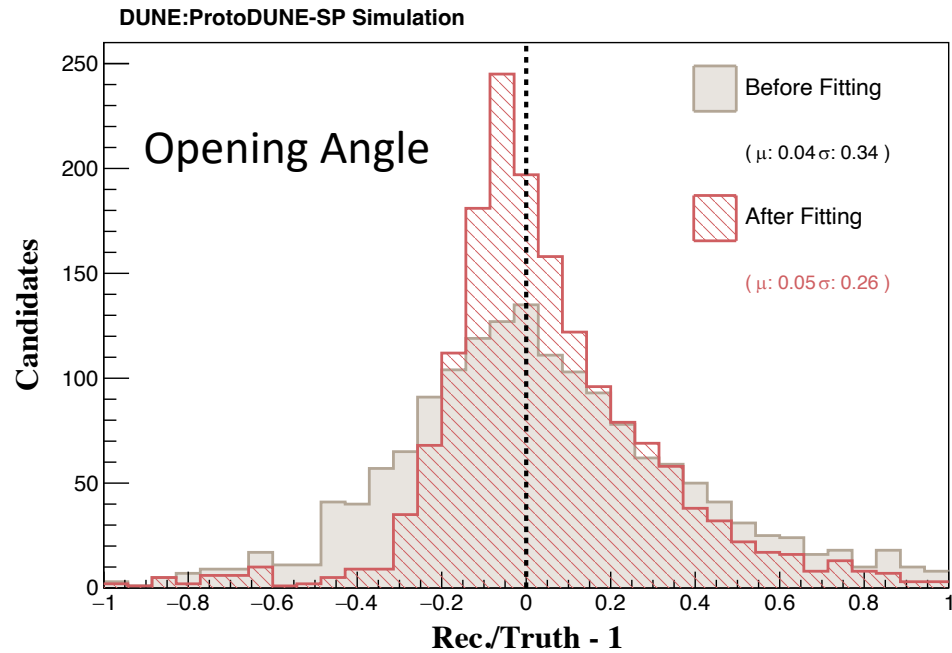
$$V_{e_1 e_2} = \frac{\sum (e_1^i - E_1^i)(e_2^i - E_2^i)}{N}$$

$i = 0, 1, \dots, N$   
 $N = \text{sample size}$



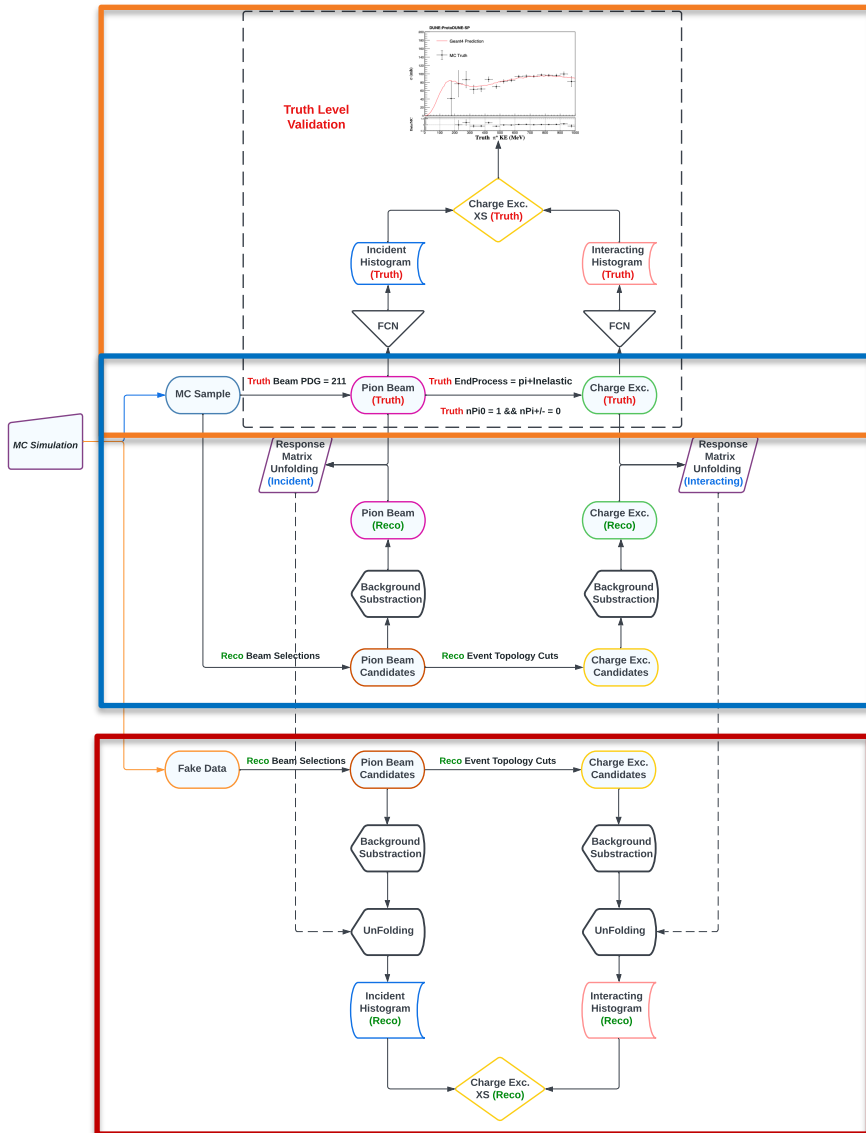
- No obvious energy dependence is found on the absolute difference of reco. and truth shower energy.
- Use the shower-energy independent CVM.

# Kinematic Fitting Results



- After the kinematic fitting, the opening angle between two showers is improved a lot.
- Events with an extreme absolute angle difference are not improved via the fitting.
- Can reconstruct  $\pi^0$  energy using leading shower E and opening angle

# Truth Level Validation and Unfolding



1

1. Truth Level Validation

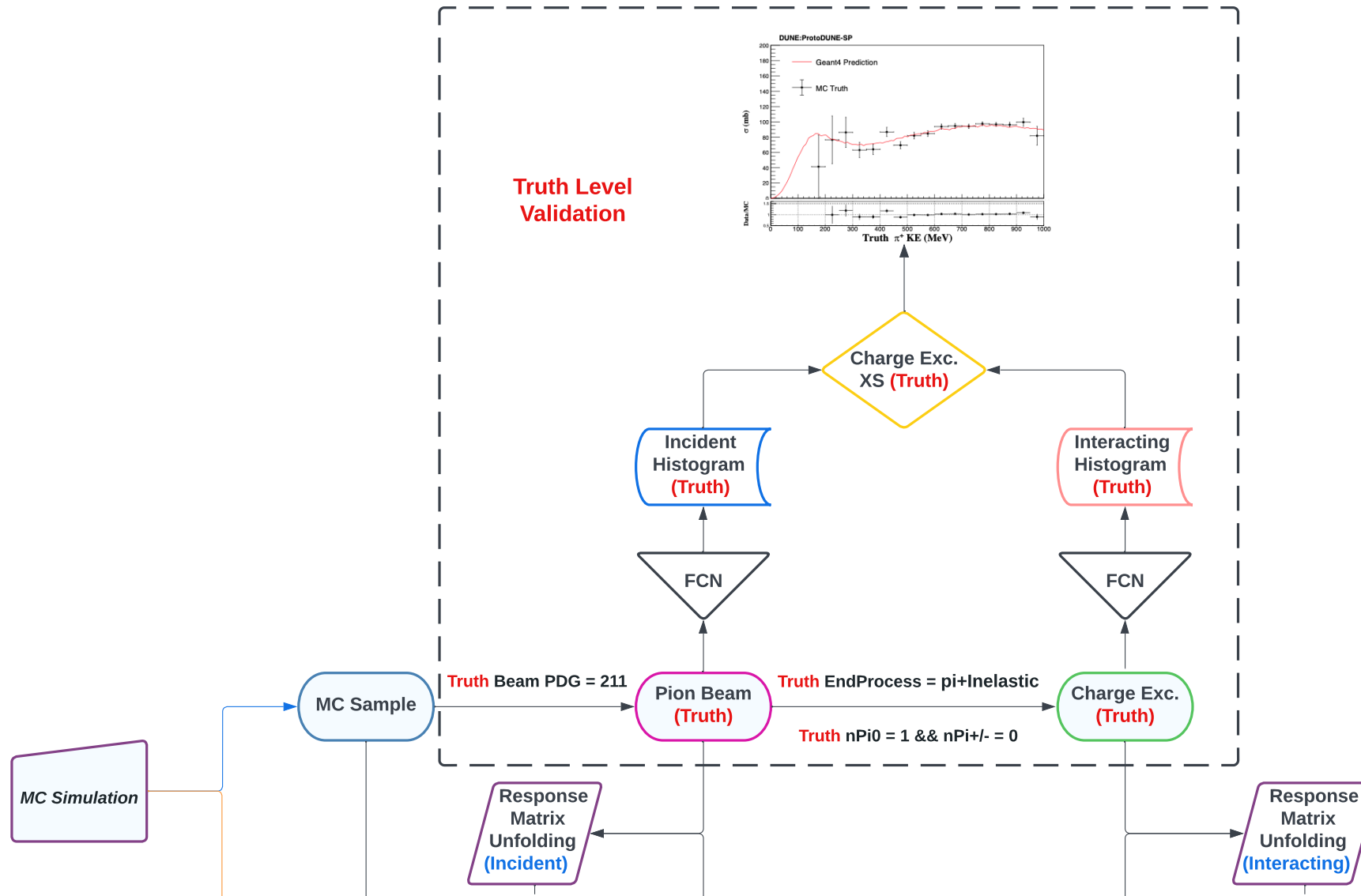
2

2. Train Response Matrix

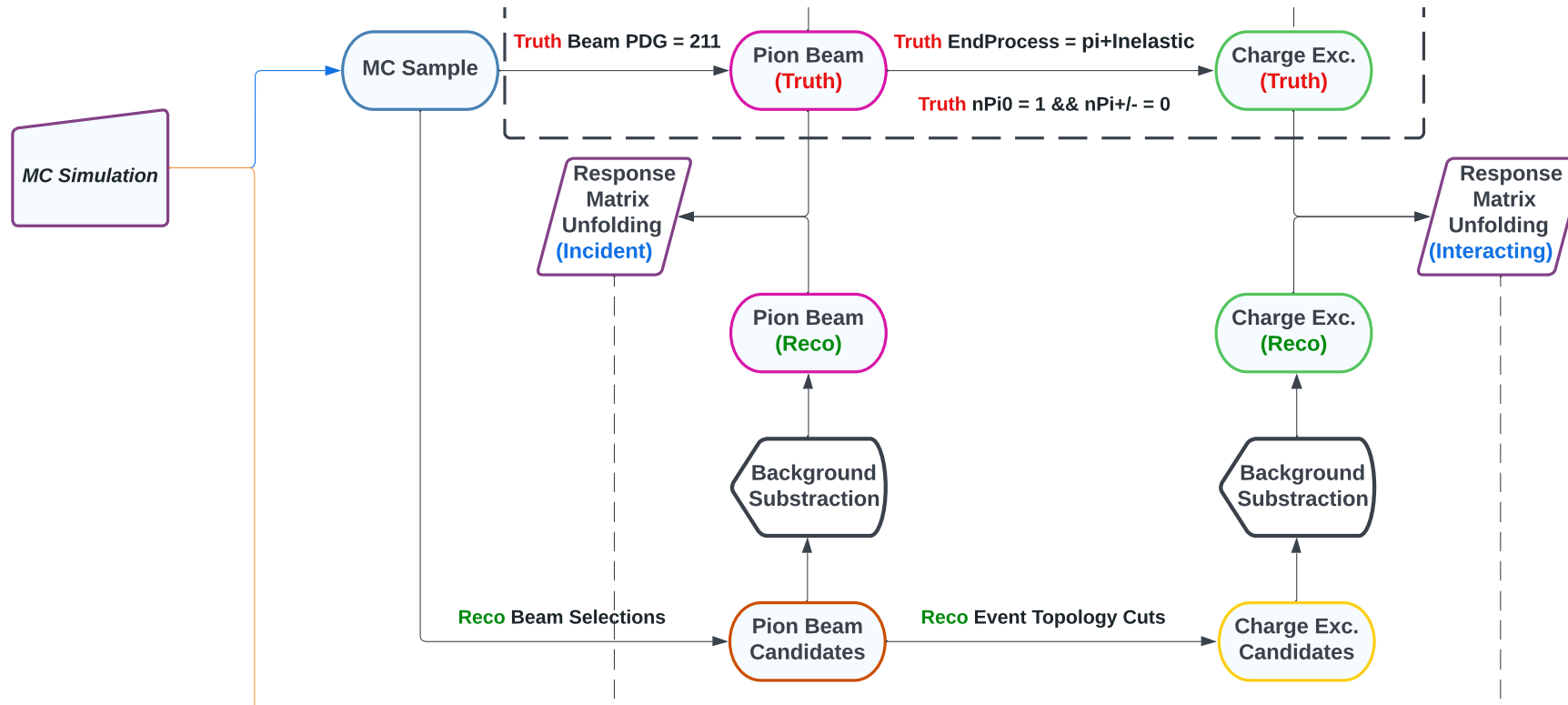
3

3. Unfolding Data

# Truth Level Validation and Unfolding

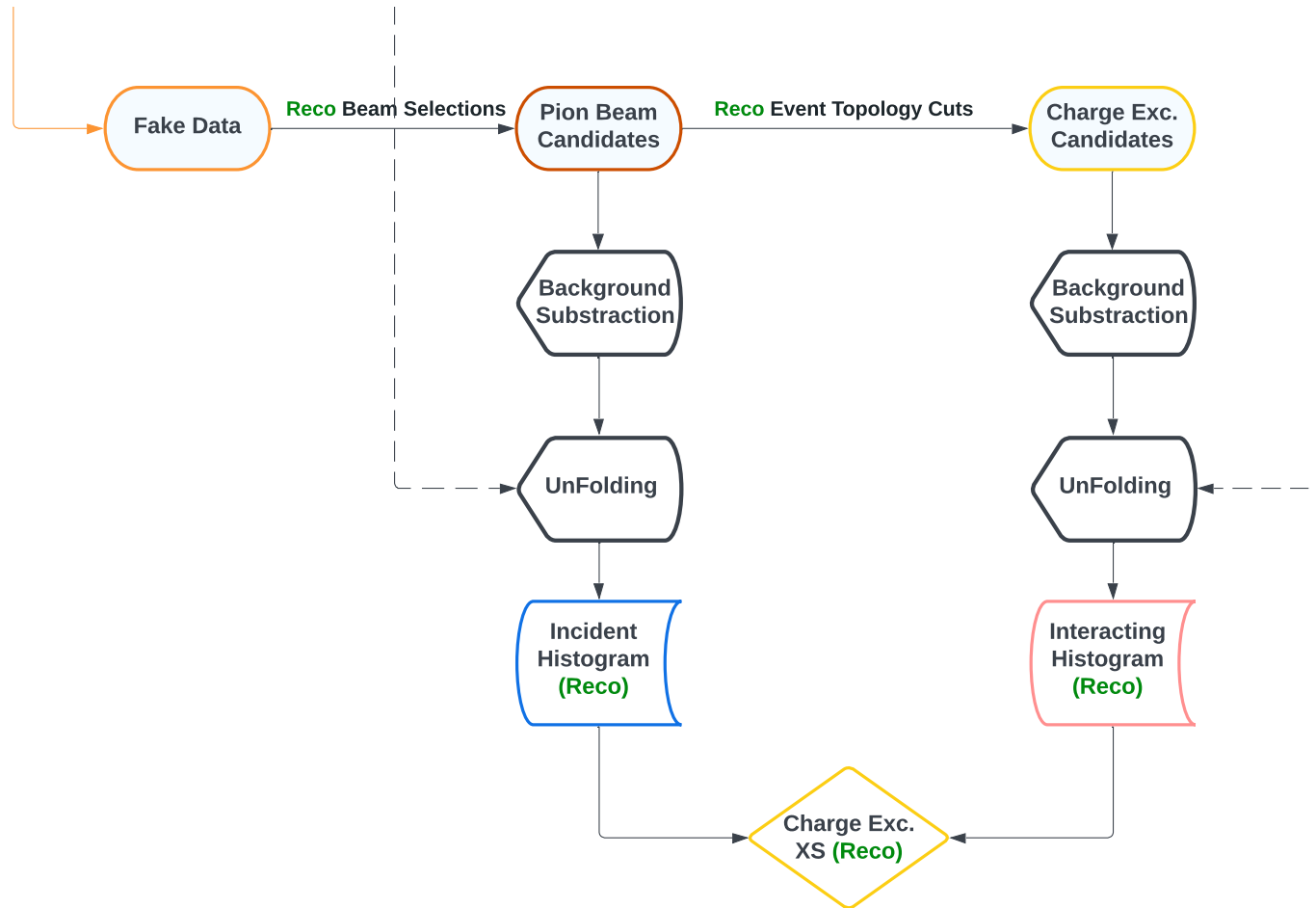


# Truth Level Validation and Unfolding





# Truth Level Validation and Unfolding



# Response Matrix

